X-Ray Powder Diffraction with Guinier - Hägg Focusing Cameras

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ABSTRACT

The Guinier - Hägg focusing camera is discussed with reference to its use as an instrument for rapid phase analysis. An actual camera and the alignment procedure employed in its setting up are described. The results obtained with the instrument are compared with those obtained with Debye - Scherrer cameras and powder diffractometers. Exposure times of 15 - 30 minutes with compounds of simple structure are roughly one-sixth of those required for Debye - Scherrer patterns. Coupled with the lower background resulting from the use of a monochromatic X-ray beam, the shorter exposure time gives a ten-fold increase in sensitivity for the detection of minor phases as compared with the Debye - Scherrer camera.

Attention is paid to the precautions taken to obtain reliable Bragg angles from Guinier - Hägg film measurements, with particular reference to calibration procedures. The evaluation of unit cell parameters from Guinier - Hägg data is discussed together with the application of tests for the presence of angle-dependent systematic errors. It is concluded that with proper calibration procedures and least squares treatment of the data, accuracies of the order of 0.005% are attainable.

A compilation of diffraction data for a number of compounds examined in the Active Central Laboratory at Studsvik is presented to exemplify the scope of this type of powder camera.

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1. INTRODUCTION

X-ray powder diffraction is a well established technique for the phase analysis of solids. Studies of minerals, reaction products of laboratory and technical-scale processes, surface coatings and corrosion products have all benefited from the introduction of powder-pattern characterization. A related application, the measurement of the dimensions and angles of the crystallographic unit cell, has afforded a powerful means for studying and understanding the phenomenon of solid solubility. At a fundamental level these cell parameter measurements serve to convert the atomic parameters, obtained in crystal structure studies, into the spatial realities of bond distances and angles for subsequent correlation with physical and chemical properties.

For most of these applications a photographic method is preferred for recording the powder pattern, largely because of its cheapness, but also because it is simple to apply. Only where accurate X-ray intensity measurements are required, as in quantitative analysis, or line profile studies, is the camera superseded by the electronically recording diffractometer.

Devices used for powder photography are usually based on the cylindrical camera, first used by Debye and Scherrer. The most popular version of this instrument in current use is the camera developed by Staumanis for precision lattice parameter measurements. Although simple to operate and maintain in routine application, this type of camera, with its 1[°] per 2 mm film ratio, suffers from limitations of resolution and line definition. Accordingly the interpretation of complex patterns is at best qualitative. Increased resolution is obtained up to a point by increasing the camera diameter (from 11.46 cm in the Straumanis to 19 cm in the Bradley - Jay camera) but the exposure times are then considerably increased. X-ray beams from conventional Coolidge tubes are divergent and an increased path length necessitates the use of more stringent collimation in order to maintain acceptable line definition.

Because of the need for collimation the Debye - Scherrer camera utilises only a fraction of the divergent X-ray beam. Improvements in camera performance have therefore been sought through beam focusing.

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This is achieved in the Seeman - Bohlin and Westgren - Phragmén cameras by reflecting the primary beam from a specimen curved to fit a circle defined by the X-ray source and the recording film. In a further development, due to Guinier, a focused beam is obtained by setting up a curved quartz crystal in the path of the divergent primary X-rays. The beam diffracted from the quartz crystal is then transmitted through the specimen which, in the form of a powder, is spread over a paper tissue. This method has the added attraction that only a narrow band of wavelengths is employed to obtain the power pattern, the curved crystal functioning as a monochrometer.

A considerable disadvantage of the focusing camera is the limitation imposed on the angular range of the pattern available for recording on a single film ($\theta_{max} \leq 50^{\circ}$ in the low angle range). For the Guinier camera there are added difficulties in aligning and maintaining in effective operation, the optically sensitive system of bent crystal, specimen holder, film cassette and associated slit systems. As a result opinion regarding the value of this type of camera is generally guarded. Thus, while text books devoted to X-ray technique invariably give full accounts of the Debye - Scherrer camera and powder diffractometer, the Guinier camera is either given a passing mention or ignored altogether.

A typical evaluation is that the Guinier camera is capable of giving diffraction patterns with a resolution approaching that of the powder diffractometer for an exposure time comparable to that of the Debye -Scherrer camera. It is often pointed out, moreover, that direct measurement of Bragg angles is not possible in the Guinier camera, since the relationship between film circle and specimen plane is not ideal. The use of an internal calibrant becomes necessary in order to determine the ratio between film distance and Bragg angle at different points along the film.

In view of the past performance of some early commercial Guinier cameras, such remarks are justified. It should be pointed out, however, that the introduction of the fine-focus X-ray tube during the early 1960's afforded a possibility for a major improvement in Guinier camera performance. This is due to the increase in the definition of the X-ray source which governs the line definition of the pattern and the ease with which the characteristic radiation is freed from the α_2 component. An added bonus is the possibility of much reduced exposure times arising from the greater intensity of the fine-focus-beam.

Full advantage of the improvements in X-ray tube performance is taken in the version of the Guinier camera developed in Uppsala by Prof. G. Hägg during the early 1950's. In 1958, two examples of this Guinier - Hägg camera were constructed for operation with $CuK\alpha$ radiation at the Stockholm laboratories of AB Atomenergi under professor Hägg's guidance. In 1966 the present writer replaced the normal focus X-ray tube used with these cameras by a Philips fine-focus tube. Subsequent attempts to realign the optical system of the instruments indicated that the monochromator support was insufficiently stable under the critical conditions imposed by the fine-focus source.

Consultation with Dr. Per Spiegelberg of the Institute for Metals Research, Stockholm, led to the abondonment of the original arrangement for pivoting the crystal and setting it at the required distance from the fine-focus anode. A new device, constructed by Mr. K. Kranz of the Institute for Metals Research and described in this report has proved to be both highly flexible for adjustment purposes and mechanically stable under long term usage. Operated with strictly monochromatic $CuK\alpha_1$ radiation, exposures are suitably short (15 - 30 minutes) for purposes of rapid phase analysis. The line definition is such that Bragg angle measurements from silicon calibrated patterns, are sufficiently precise to permit detection of cell parameter changes at the 0.01 % level, independent of cell symmetry. This degree of precision has been found to have particular value in connection with the indexing of powder patterns of new structures.

Since the main problem with the Guinier-type camera is to ensure that performance is consistently of the above quality, a description of these cameras and the method adopted for their adjustment seems called for. A brief summary of the principles and problems of powder diffraction is included as a means of highlighting the special advantages of the focusing camera. The report is supplemented with some results of an investigation into the reliability of cell dimension measurements based on calibrated Guinier - Hägg patterns. The abreviations D - S and G - H used throughout refer to Debye -Scherrer and Guinier - Hägg respectively, in the context of the cameras associated with these workers.

2. GENERAL CONSIDERATIONS

2.1. Diffraction in Crystals

The diffraction of X-rays in crystals can be understood with reference to Fig. 1a. The crystal is imagined as comprising sets of parallel planes which have the property of being able to scatter X-rays. Each set of planes is characterized by a particular separation, the interplanar distance d, measured along the normal.

A parallel beam of X-rays is defined by placing a collimator close to the irradiated crystal. X-rays travelling along the beam are then associated with a wave front perpendicular to the beam axis; wave fronts travel down the beam from the source with a separation of λ , the wavelength of the radiation.

As each component of a wave front strikes a crystal plane, scattering of a fraction of the radiation occurs at the point of impact, the scattered radiation being spherically distributed. The occurrence of scattering in successive crystal planes gives rise to interference phenomena as shown in Fig. 1a. Here, the components A, B and C are seen to strike the first three planes of a set at points O, P and Q along the normal. Inclination of the wave front at θ to the normal leads to a path difference for the front, as it strikes successive planes at these points, which reaches a maximum at $\theta = 90^{\circ}$. When θ attains an angle such that the path difference corresponds to an integral number of wavelengths, $n\lambda$, radiation scattered elastically at O, P and Q will reinforce to produce a wavefront at the same angle to, but on the opposite side of, the normal. This "reflected" wavefront is contained entirely in the plane defined by the path of the incident beam and the normal to the set of diffracting planes.

From a simple consideration of the quantities involved in Fig. 1c the condition for the generation of a diffracted beam is then given by the Bragg equation, $n\lambda = 2d \sin \theta$

The normal to each set of crystal planes is inclined at a specific angle to the crystal axes, the angle being defined by the Miller indices hkl of the planes and by the dimensions of the unit cell a_0 , b_0 , c_0 measured along the cell ledges and the interaxial angles, α , β , γ . A purely trigonometrical relationship can be derived to relate these quantities and the d spacing along the normal to a set of planes hkl. Substituting for d in the Bragg equation, the general, triclinic case can be described by the linear expression

$$Q_{hk\ell} = Ah^{2} + Bk^{2} + C\ell^{2} + Dh\ell + Ek\ell + Fhk = n^{2}/d^{2}_{hk\ell}$$

where

$$\begin{split} & \mathbf{Q}_{\mathbf{h}\mathbf{k}\ell} = 4 \sin^2 \theta_{\mathbf{h}\mathbf{k}\ell} / \lambda^2 \\ & \mathbf{A} = \mathbf{b}^2 \mathbf{c}^2 \sin^2 \alpha / \mathbf{V}^2 \\ & \mathbf{B} = \mathbf{c}^2 \mathbf{a}^2 \sin^2 \beta / \mathbf{V}^2 \\ & \mathbf{C} = \mathbf{a}^2 \mathbf{b}^2 \sin^2 \gamma / \mathbf{V}^2 \\ & \mathbf{D} = 2 \mathbf{a} \mathbf{b}^2 \mathbf{c} \sin \alpha \sin \gamma \left(\cos \alpha \cos \gamma - \cos \beta / \sin \alpha \sin \gamma \right) / \mathbf{V}^2 \\ & \mathbf{E} = 2 \mathbf{a}^2 \mathbf{b} \mathbf{c} \sin \beta \sin \gamma \left(\cos \beta \cos \gamma - \cos \alpha / \sin \beta \sin \gamma \right) / \mathbf{V}^2 \\ & \mathbf{F} = 2 \mathbf{a} \mathbf{b} \mathbf{c}^2 \sin \alpha \sin \beta \left(\cos \alpha \cos \beta - \cos \gamma / \sin \alpha \sin \beta \right) / \mathbf{V}^2 \end{split}$$

and V, the volume of the unit cell is given by

 $abc(1 + 2\cos\alpha\cos\beta\cos\gamma-\cos^2\alpha-\cos^2\beta-\cos^2\gamma)^{1/2}$

Simplifications of this expression obtained with increase of symmetry are given in Table 1.

Accordingly if the hkł indices corresponding to a number of independent reflections are known, measurement of the angles, $2\theta_{hkl}$, between the diffracted and transmitted beams can be used to determine the unit cell dimensions.

In a single crystal, each set of crystal planes and the associated normal, have a specific orientation with respect to the crystal axes. Diffraction from such a crystal therefore yields a pattern of reflected beams which have a three dimensional distribution. This pattern is related to the symmetry and size of the unit cell and its orientation in the primary beam.

The measurement of 2θ in this three dimensional distribution presents serious problems of instrumentation since, in order to bring the different sets of hkl planes into the reflecting position, the crystal must be rotated through two mutually perpendicular arcs with respect to the X-ray beam [1]. These rotations must be known with a precision of at least 0.01° in order to obtain reliable values of 2θ for the measurement of accurate cell dimensions [2].

2.2. The Debye - Scherrer Effect

If the single crystal is reduced to a powder comprising a large number of randomly oriented crystallites, a given set of crystal planes of spacing $d_{hk\ell}$ will be associated with a corresponding number of normals having spherical distribution. On irradiation with a parallel beam of X-rays, only those planes whose normals make an angle \emptyset (= 90- $\theta_{hk\ell}$) with the incident beam fulfill the Bragg condition. These normals lie on the surface of a cone of semi-angle \emptyset with the <u>incident</u> X-ray beam as cone axis. Each normal gives rise to a diffracted beam and these accordingly lie on the surface of a second cone of semi-angle 20 to the <u>transmitted</u> beam. The process of cone formation, described by Debye and Scherrer [3], is depicted in Fig. 1b.

The three dimensional resolution afforded by single crystal diffraction is clearly lost when the specimen is a polycrystalline mass. Whereas in a single crystal, each set of hkl planes gives rise to a narrow, discrete beam of reflected X-rays, the set is represented in a polycrystalline specimen by a cone of reflection. The diffraction pattern accordingly comprises a family of such cones with the primary X-ray beam as common axis as depicted in Fig. 2a.

In compensation for the loss of three dimensional resolution, the powder pattern offers a considerable simplification of the requirements for measuring $\theta_{hk\ell}$. For a specimen with a truly random distribution of crystallites, all the reflections can be found on a single circle centred on the specimen with the X-ray beam as diameter. In the simplest

powder diffraction instrument, the Debye - Scherrer (D - S) camera, the reflections are recorded by placing a strip of photographic film on this circle as shown in Fig. 2a. The angle $\theta_{hk\ell}$ is then proportional to the interval S measured between the exit point of the primary beam and the point on the equator (defined by the tangent between film cylinder and recording circle) where the cone of reflection emerges.

As cell dimensions grow larger and cell symmetries become lower the crowding of powder cones increases, particularly at values of θ between 40 and 60[°]. Vand has considered the general distribution of reflections in a powder pattern in terms of the interaction of the Ewald sphere with the reciprocal lattice [4]. For reflection down to $\theta_{hk\ell}$ corresponding to interplanar spacing $d_{hk\ell}$ the radius of the reflecting sphere in reciprocal space is 1/d and its volume is accordingly 4 $\pi/3d^3$. For a unit cell of volume V, the reflecting sphere will contain 4 $\pi V/3d^3$ reciprocal lattice points each of which gives rise to a cone of reflection in the powder sample. Symmetry, however, limits the number of independent reciprocal lattice points, an effect represented by the multiplicity factor p for general hk& reflections. Thus p is 2 for triclinic, 4 for monoclinic, 6 for orthorhomibic, 8 for tetragonal and 48 for cubic crystals. Neglecting the special cases where, for example, one or two indices are identical or zero the average number of powder lines is given approximately by

$$\bar{n} = 4 \pi V/3pd^3$$
$$= (32 \pi V/3p\lambda^3) \cdot \sin^3\theta$$

The average number of reflections per unit of Bragg angle is then

$$d\bar{n}/d\theta = (32 \pi V/p\lambda^3) \sin^2\theta\cos\theta$$

Fig. 2b shows the curve of this expression as a function of θ together with a representation of the change in reflection density along the length of the powder pattern.

2.3. Influence of Specimen Condition on Pattern Definition

The angular range, $\Delta \theta$, over which X-rays are diffracted by a set of crystal planes, spacing d, is governed by the number of planes N

which are stacked uniformly along the normal, and which contribute to reinforcement at Bragg angle θ and cancellation at $\theta \pm \Delta \theta/2$. For values of N = 300 and d = 1 Å, the resulting spread may be as large as 2^o (2 θ). As N exceeds 3000, however, 90% of the diffracted radiation can be expected to lie within an angular range of 0.2^o (2 θ). The definition of the diffraction pattern is therefore determined to some extent by the crystallite size and the degree to which the presence of inelastic strains and chemical inhomogeneities in the crystallites disturb the regular stacking of reflecting planes.

Similarly, a powder specimen containing crystals above 1 μ in size tend to produce discontinuous powder rings. This effect is discounted for crystal sizes up to 5 μ by rotating the powder specimen in the X-ray beam to smooth out the individual reflections. It is enhanced, however, but the use of fine collimators such that the width of the X-ray beam approaches the mean size of the individual crystals. For crystal sizes beyond 10 μ a radial spread of the Xray spots, leading to non-uniform broadening of the reflections, becomes evident. This is largely due to the effects of collimator geometry. In the case of non-monochromatic X-rays, it may also arise from the scattering of wavelengths within the spectral range but differing from those of the characteristic radiation (see section 2.5).

Optimum overall sharpness of the D - S pattern is afforded by crystallites with sizes between 0.25 and 5 μ in a strain-free condition. Departure from this condition has a particular bearing upon cell dimension measurements since line broadening clearly reduces the precision with which the diffraction angles can be determined. Specimen dependent line broadening is a function of diffraction angle, increasing as θ increases. As a result, marked loss of pattern definition above $40^{\circ}(\theta)$ is experienced for specimens which are either cold worked or comprise crystallites less than 0.1 μ in size. As will be described in the next section, the angular range above $40^{\circ}(\theta)$ in D - S patterns is vital to the evaluation of reliable cell dimensions.

2.4. Requirements and Problems of Powder Photography

Powder photography has two main applications in phase analysis, namely the identification of crystalline phases and the measurement of the unit cell dimensions by which a phase is characterized. The main requirements for such work are good resolution and maximum sharpness of the pattern and a low background from unwanted components of the X-ray spectrum.

For the measurement of unit cell dimensions and angles, a guide to the precision of the measurement at different points on the pattern is given by differentiating the Bragg equation, whence

 $|\Delta d| = d \cot \theta \Delta \theta$

Here Δd represents the random error in the measurement of $d_{hk\ell}$ produced by a corresponding error $\Delta \theta_{in}$ the measurement of the Bragg angle.

Parish and Wilson [5] give curves (Fig 3) based on this expression for the percentage precision of d as a function of θ for various values of the error $\Delta \theta$. The improvement in precision to be expected from measurements at high θ is exemplified in the accompanying table constructed for a D - S camera of 11.46 cm diameter (1°(θ) = 2 mm(S), giving $\Delta \theta = 0.005^{\circ}$ for a measurement error σ_{c} of 0.01 mm).

θ	$ \Delta d/d \cdot 10^3$
20	13.738
40	4.347
60	2.887
70	1.819
80	0.882
85	0.438

The random error is thus reduced to very small proportions at high Bragg angles and, using sophisticated methods for scanning the diffraction profile, accuracies of 1 part in 10^6 have been claimed. The measurements are open to systematic error, however, and for a number of reasons described briefly below and more exhaustively in ref. [6] it is rarely possible to achieve accuracies of better than 1 part in 10^3 from D - S films.

The main systematic errors in D - S measurements arise from diffraction in a cylindrical specimen which is ideally located at the exact centre of the recording circle. Divergence of the diffracted beam, absorption in the specimen and its eccentricity with respect to the recording circle all contribute to displace the diffraction peak to higher values of θ . The effect diminishes with increasing θ and mathematical expressions have been derived to permit correction of the D - S measurements for these θ dependent errors (Taylor and Sinclair [7] and Nelson and Riley [8]). According to Cohen [9] the corrections are conveniently applied using the method of least squares, coefficients for the θ dependent terms being derived from the analysis of a statistically suitable number of measurements. Accordingly, for hexagonal and tetragonal unit cells which are defined by two cell dimensions, the number of parameters to be determined is effectively doubled, necessitating a corresponding increase in the number of observations in order to maintain statistical accuracy.

As explained in 2.2, the D - S pattern attains maximum line density in the region 40 - $60^{\circ}(\theta)$. For non-cubic symmetries and CuK radiation, unit cells greater than 6 Å tend to produce line overlap in this region. At angles above $60^{\circ}(\theta)$ small differences in cell dimensions produce appreciable changes in diffraction angle. Accordingly, for noncubic cells, reflections may occur in a very different order to that expected on the basis of approximate cell dimensions. Clearly, in this region of the film the assignment of erroneous indices becomes increasingly possible.

Difficulties of a physical nature serve to reduce the definition of the pattern at successively higher angles. The effect of beam divergence, K α doublet separation and the small but finite spread of λ about the value for the characteristic radiation all contribute to broaden the reflections. This broadening increases with θ , the $\alpha_1 - \alpha_2$ broadening affecting line definition at $20 < \theta < 35$ while angular divergence and spectral spread exert their effects in the region $\theta > 60^{\circ}$. Specimendependent line broadening produced by micro-strains and sub-micron inhomogeneities is similarly marked in this angular range, as described in section 2. 3, and careful treatment of the X-ray sample is necessary to optimize the sharpness of the pattern for precision measurements. Finally, thermal vibrations of the diffracting atoms lead to an attenuation of intensity, the effect becoming more pronounced with increasing θ . For many organic materials, complexes and molecular

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compounds, the effect of this temperature factor virtually eliminates all detail above $50^{\circ}(\theta)$ in diffraction patterns obtained with CuK α radiation.

Treated as a whole, the angular range above $40^{\circ}(\theta)$ is seen to present considerable difficulties as regards the accurate location of the peak maximum for a given hkl reflection within the expected precision for the measurement. For the general, non-cubic case, there is, in fact, only a limited chance of obtaining reliable data from this region of the D - S pattern under routine conditions. There is, consequently, a very great risk that results obtained from reflections in the measurable part of the pattern will be severely affected by both random and systematic errors. To some extent the random error can be reduced by using a camera with a larger film radius but the effectiveness of this measure is limited by the increase in line width produced by beam divergence. Stricter collimation may be used to combat the effects of divergence but only at the expense of X-ray intensity and a useful exposure time. In any case, the sources of systematic error remain.

From the foregoing it is evident that a general purpose camera for powder diffraction work should overcome the principal limitations of the D - S camera. Thus, it should yield sharply defined reflections in the angular range up to at least $45^{\circ}(\theta)$. It should be capable of yielding good resolution, i. e. the effective camera diameter should yield at least 2° per mm film circumference. Finally the specimen should be ideally thin to minimize the systematic error produced by absorption.

In the following sections it will be shown that a carefully adjusted focusing camera of the Guinier type is capable of fulfilling these requirements.

2.5. Problems Associated with the X-ray Spectrum

A major contribution to the complexity of the powder pattern is the polychromatic character of the incident X-ray beam. The typical X-ray spectrum comprises a continuum of low intensity and characteristic peaks, $K\beta_1$, $K\alpha_1$, $K\alpha_2$ etc. (Fig. 4) with wavelengths dependent on the nature of the element used as anode in the X-ray tube. For a copper anode $\lambda\beta = 1.39217$, $\lambda\alpha_1 = 1.54051$ and $\lambda\alpha_2 = 1.54434$ Å.

In the instance of copper radiation, the above distribution permits the removal of the K β peak by absorption in a nickel foil. The intensity of the α_1 peak, however, is attenuated by roughly 45% in raising the ratio $K\alpha_1/K\beta_1$ to 100/1 using such a filter. A narrow range of wavelengths about the combined K α peak may be selected by transmitting the beam through balanced filters of Ni/Co foils. While useful in reducing the extent of background scattering due to the continuum, the discrimination achieved, $\Delta\lambda = 0.12$ Å, is insufficient to distinguish between the components of the $\alpha_1 \alpha_2$ doublet ($\Delta\lambda \alpha_1 \alpha_2 = 0.0038$ Å).

In the low-angle region of the D - S pattern, the $\alpha_1 \alpha_2$ doublet is unresolved. As θ increases beyond 20°, however, reflections broaden as the α_1 and α_2 components separate in accordance with the requirements of the Bragg equation. In this angular region an estimate of diffraction angle corresponding to a particular value of λ may therefore be accompanied by a substantial error. Beyond $\theta = 35^{\circ}$, the spectral components of the reflections are resolved, thereby doubling the risk of overlapping and near coincidence in patterns of non-cubic materials.

2.6. Crystal Monochromatization

2.6.1. Parallel X-ray Beams

An effective method for isolating a narrow band of wavelengths from the X-ray spectrum utilises diffraction-reflection from a suitable face of a single crystal. The crystal is inclined at an angle to the primary beam so that for the wavelength selected, a set of strongly diffracting planes occupies the reflecting position in accordance with the Bragg condition. The principal weakness of the method is that only a fraction of the available X-rays is reflected, most being transmitted through, or absorbed in, the monochromator crystal. The practical application of crystal monochromatization therefore depends upon techniques for optimizing the diffraction conditions.

Diffraction from a plane crystal monochromator is depicted in Fig. 5a, the crystal surface being cut parallel to the reflecting planes. In Fig. 5b, the reflecting surface is cut at an angle, α , to the diffracting planes. By this means an increase in beam density is achieved by fore-shortening the view of the X-ray source. This tilted surface technique

is theoretically capable of yielding a nearly two-fold increase in intensity for a parallel beam. The gain is in fact limited to between 10 and 20% by comparison with the plane-parallel method owing to intensity losses through extinction in the crystal.

Although the tilted surface effectively concentrates the primary beam, collimation, with attendant loss of intensity, is still necessary to obtain sharp definition, owing to the natural divergence of the primary X-ray beam. Curving the crystal serves, however, to focus the divergent beam and stringent collimation becomes unnecessary.

2.6.2. Geometrical Conditions for the Focusing of Divergent Beams

The principle of the focusing monochromator follows from the theorem that the chord of a circle subtends equal angles at all points on its arc. In Fig. 5c the divergent beam from source S is represented by two components which strike a reflecting curved surface at points A and B. This surface and the source lie on the same circle of radius R. If the components at A and B are reflected to yield the same angle, $2\emptyset$ they will focus at point F, SF being the chord and SABF the arc referred to above.

In the simplest approach, due to Johann, the reflecting surface is a crystal cut in a direction parallel to a set of diffracting planes and curved to a radius of R (Fig. 6a). The diffracting condition is only fulfilled, however, when S, O and F lie on the surface of a circle of radius R/2; the crystal is accordingly only tangential to the focusing circle at O. The source is thus not clearly defined with respect to the diffracting surface and the focus has a width dependent upon the length of crystal irradiated, i. e. upon the positions of S and O relative to the focusing circle and the caustic circle, to which all diffracted rays are tangential.

The aberrations inherent in the Johann crystal are eliminated in the geometry due to Johansson. Here the diffracting surface of the crystal is first ground to a radius of 2R and then curved, by the application of pressure, to the radius R of the focusing circle (Fig. 6b). As in the case of the Johann crystal S and F are symmetrical about the point O about which the crystal is ground and bent. The angle $\oint = \pi/2 - \theta$ and the source-crystal and crystal-focus distances are thus $SO = OF = 2R \sin\theta$

Substituting $\lambda/2d = \sin\theta$ from the Bragg equation these distances are seen to correspond to $R\lambda/d$.

Guinier [10] advises the use of an asymmetric version of the Johansson crystal to allow a greater crystal-focus separation, thus increasing the available working space while maintaining a short source-crystal separation (Fig. 7a). For this purpose the crystal is ground at an angle α to the diffracting planes and the critical distances become

SO = 2R sin (θ - α) OF = 2R sin (θ + α)

3. PRACTICAL CONSIDERATIONS

3.1. Guinier Focusing Geometry

A powder specimen placed in the X-ray beam reflected from a curved crystal monochromator should give a pattern which is sharply defined along the circumference of a circle containing the powder specimen and the focus of the incident beam. The main requirement here is that the specimen should be infinitesimally thin. If film is used to record the pattern, it too should comply with this requirement, double coated film being stripped of emulsion on the side furthest from the specimen to avoid diffuse and staggered patterns.

In the symmetrical arrangement (Fig. 7b) the incident beam, normal to the plane of the specimen, forms a diameter of the recording circle. The expression for S, the diffraction interval along the circle, is then $\pi R\theta/45$, an improvement by a factor of two over the resolution in a D - S camera of the same radius.

The main limitation of the symmetrical Guinier arrangement is the small angular range, roughly $30^{\circ}(\theta)$, which can usefully be recorded. For radiation containing both α_1 and α_2 components, there is, moreover, an asymmetry in the pattern due to differences in the way these peaks become separated on either side of the primary beam. Thus in the primary beam itself, the α_2 component is reflected from the crystal with a slightly greater Bragg angle (smaller \emptyset) than the α_1 component. In subsequent diffraction at the specimen surface, those rays taking a direction which is generally parallel to that of the beam striking the monochromator, experience a focusing effect as, with increasing θ , the α_2 peaks first converge on, and then cross over the α_1 peaks (Fig. 8a). The effect is to produce reflections which are broad by comparison with the primary focus, resolution of α_1 and α_2 occurring at about 25 to $30^{\circ}(\theta)$. For X-rays reflected in the antiparallel direction on the other hand, the $\alpha_1 - \alpha_2$ separation observed at the focus is further increased along the circumference of the recording circle as θ increases (Fig. 8b). By comparison with the parallel direction, reflections on this side of the focus are sharper unless the pattern is of such complexity that α_2 peaks begin to merge with the α_1 peaks of neighbouring reflections.

An asymmetrical setting of the film cassette (Fig. 8) permits the recording of diffraction patterns up to 45 or $50^{\circ}(\theta)$ depending upon the departure from 90° in the angle ζ , between the monochromatic beam axis and the tangent to the recording circle. Whether the cassette is located in the parallel or antiparallel position is a matter of choice dictated by a consideration of the influence of the $\alpha_1 \alpha_2$ separation on the sharpness, as opposed to the overall resolution, of the pattern.

3.2. The Monochromator Crystal

Elimination of the K β component from the X-ray beam is fairly easily achieved. The difference between the wavelengths of the K α and K β components is such that a simple setting of the monochromator crystal to the angle prescribed by the Bragg condition is generally effective. In the instance of focusing monochromators discrimination is assisted by the requirement for wavelength-dependent distances between source, crystal and focus. These distances are so very different for the K α and K β components, however, that a precise setting is not essential.

Discrimination between the components of the K α doublet is clearly more difficult in view of their closely similar wavelengths. The main requirement is for an accurately defined focusing geometry. Otherwise the attenuation of the α_1 component will be too great when the angle of the crystal is adjusted to eliminate α_2 . Factors affecting the definition of the focusing geometry are the width of the X-ray source and the mosaic spread in the monochromator crystal. These, if too large, limit descrimination. Alternatively a crystal which is too perfect, although offering good discrimination, yields a much weakened monocrhomatic beam owing to extinction effects.

A variety of materials have been tried in curved crystal monochromators for X-ray work. A compilation has been prepared based on the properties of the monochromatised beam, which should be strong with only a small width, and those of the crystal which should be physically and chemically stable, contain a low concentration of imperfections and be capable of being formed to the required curvature [11].

Quartz, cleaved parallel to $(10\overline{1}1)$, has traditionally been employed in Guinier cameras, owing to its good elastic properties and high discriminatory power. The main drawback is the relative weakness of the diffracted beam.

Ideally imperfect crystals should contain small mosaic blocks of 10^{-3} mm size misoriented by not more than a few minutes of arc in order to minimize extinction. An approach to this condition in quartz crystals is made by subjecting them to an elastic stress; the reflected intensity can thus be increased by a factor of up to 20 [12]. The reflectence may also be increased by gently abrading the crystal face with a soft lead pencil to introduce a surface mosaic.

Oriented pyrolitic graphite appears to be superior to other materials as regards reflecting power; it gives a roughly fifteen-fold increase in the intensity of CuK α radiation by comparison with quartz according to calculations by Renninger [13]. For a beam divergence which is less than the mosaic spread of the graphite the diffracted intensity is as much as 50% of the incident intensity for CuK α radiation [14]. The main drawback to the use of pyrolitic graphite is the relatively high mosaic spread in the material, generally of the order of 0. 4[°], which severely limits peak resolution. Reduction of this spread by a factor of five or six is necessary before graphite can be considered suitable for Guinier camera application.

The quartz crystals employed in the cameras constructed at Atomenergi were manufactured by Messers. A. Jobin and G. Yvon, 26 rue Berthollet, Arcueil (Seine), France. The specifications are for a quartz lamina with dimensions Length = 35 mm, Height = 15 mm, Thickness = 0.3 mm with H parallel to [010]. The face LH is cut at $\alpha = 3^{\circ}$ to the

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 $(10\overline{1}1)$ set of crystal planes and ground to a radius of 500 mm (2R), the cylinder axis being parallel to H.

The lamina is mounted in a curved press which on tightening bends the crystal to the required radius of 250 mm. The press is mounted at the specified distance SO from the anode of the X-ray tube, O being the point about which the press is rotated to select the required wavelength. For use with a Cu anode the critical distances and angles for the three main spectral components are as follows, calculated on the basis of $d_{10\bar{1}1} = 3.344$ Å, $\alpha = 3^{\circ}$ and R = 250 mm.

	κ _β	Kα	Kα ₂
λ(Â)	1.39217	1.54051	1.54434
θ ^o	12.019	13.321	13.355
SO (D ₁) mm	78.4	89.6	89.9
$OF(D_2) mm$	129.6	140.5	140.8

Experience shows that in fact quartz crystals generally exhibit departures in D_1 and D_2 from these figures, probably owing to variability in the angle α . Thus for the instruments described here the D_1 distances are 91 and 88 mm. Such departures are of little significance, however, as long as D_1 does not exceed 100 mm and D_2 is not less than 130 mm. A method for locating the crystal at the distance from the anode appropriate to the real values of R and α is given in section 4.3b, based on the account given in ref. [10].

3.3. Mounting the Crystal

The crystal is supported in the press, A (Fig. 9) comprising two brass blocks with a cylindrical interface of radius 250 mm (R). The two halves of the press are drawn together by four spring-loaded bolts, B, until the lamina assumes the curvature of the interface. The crystal planes are now cylindrically curved with radius R. Care should be taken in drawing up the screws to avoid uneven pressures which might crack the fragile lamina. To this end, crystal and press surfaces are first washed free of dust particles with alcohol. In addition, a seating for the lamina can be improvised from a length of sellotape pressed against the surface of the concave block, C, parallel to the lower edge. Resting the lamina on this thin edge ensures a common orientation for the cylinder axes of press and crystal during the tightening of the bolts.

The press is then mounted on plate D, which extends into an arm normal to the cylinder axis. This plate is, in turn, located on slide E which permits lateral translation of the crystal axis with respect to the primary beam. The stability of the alignment and, therefore, the performance of the camera as a whole, depends ultimately on the means used to unite slide and press, remembering that free rotation of the press is necessary to bring the crystal into the reflecting position. The device used here is that of a hollow, conical pivot, F, mounted on the underside of plate D and threaded to receive set screw G. Pivot F slots into the conical hole in slide E, the set screw being drawn up against the tension of spring H until the two surfaces of slide and plate are in firm contact. Experience shows that with lubricated surfaces, rotation of the press is smooth without being disturbed by rocking about the pivot axis.

The slide is now inserted into V-block I, and fastened in position, temporarily, with one of the fibre screws, J. The V-block, I, is located on the base plate of the camera with the help of pivot K and two bolts passed through the slotted holes L. These slots afford a limited rotation of 3° for the V-block, permitting a preliminary setting of the monochromator in accordance with the take-off angle selected for the primary beam axis.

3.4. The X-ray Source

The use of a quartz crystal for discriminating between the α_1 and α_2 components of the X-ray spectrum is enhanced by the use of a fine focus X-ray source. In this respect the introduction of fine focus tubes in the early 1960's is to be regarded as a vital step in the application of Guinier cameras for routine X-ray analysis. These tubes are preferably used in the line focus orientation, the cylindrical axis of the crystal being parallel with the image of the filament on the anode of the tube. In this position, the Philips FF tube (Copper anode PW 25633/62) used with the Atomenergi cameras affords a line image which is 8 mm long

and 0.02 mm braod viewed at an angle of 3° to the plane of the anode. In addition to providing a more sharply defined camera geometry, such tubes afford X-ray beams which are less subject to air scattering than normal focus tubes. Experience shows, however, that setting up the monochromator and cassette with a fine-focus tube is a more critical operation owing, presumably, to the reduced tolerance in the SO and OF distances imposed by the sharp definition of the source.

In this connection, the mechanical stability of the X-ray tube shield with respect to the focusing camera is an important factor as regards long term performance. Brackets for mounting the tube shield in a horizontal direction are particularly susceptible to mechanical vibration. In the present case it became necessary to insert extra supports between the tube shield and the bench bearing the cameras. In this way mm-size variations in the height of the X-ray tube window, which had previously been encountered, were eliminated.

4. SETTING UP THE CAMERA

4.1. Component Parts

The interior of the Guinier - Hägg camera is depicted in Fig. 10. The component parts are mounted on a base plate, I, located inside a heavy-duty steel casing, II, with the help of three levelling screws, A, B and C, seated on a slot, a V and a plane respectively. The casing is mounted within a framework of flat rails III which permit translocation of the camera parallel to the X-ray tube axis. The casing may be locked in position by tightening a pair of setting screws Kl, K2 against the front and rear walls; Kl may be fitted with a dial for precise setting.

Resting on the base plate are the monochromator assembly, IV, comprising crystal press and slit system, and the sample-holder/cassette assembly, V, mounted on a common plate U. This assembly, V, consists of a circular specimen holder, E, and its associated slit system, the film cassette, F, and the specimen rotating mechanism, G. The cassette is positioned with three legs on its own moveable plate, H, permitting adjustment with respect to the specimen surface so that the requirement of tangentiality with the focusing circle can be met.

4.2. Preliminary Steps

- a) With the base plate resting on the bench, check that there is a common height above the plate for the mid-points of monochromator, sample holder, cassette window and the associated slit systems.
- b) Locate the cassette in its approximate position with the help of plate H; a line at 30 40° to the plane of the specimen should coincide with the line scored in the top of the cassette, passing from window to primary beam stop. The required distance from the specimen surface can be gauged with the help of a thin rod, cut to match the true cassette diameter. This is held inside the cassette with plast-icine so that it coincides with the diameter normal to the window through which it projects. On completion of this adjustment the triangular plate, H, is secured in position (see, however, 4.5.f).
- c) The approximate height of the base plate above the floor of the casing is obtained as follows. With the base plate removed the X-ray beam is admitted through the entry port of the casing and its vertical extension is registered on a piece of fluorescent (ZnS) screen mounted in plasticine. The mid-point of this extension is noted with respect to a set of horizontal lines scored in the surface of the screen and its height from the floor of the cassette is then measured.

The levelling screws A, B and C are now adjusted until the midpoint of the monochromator press is at the same height from the bench top as the midpoint of the X-ray beam from the floor of the casing.

4.3. Adjustment of Monochromator (Sample Assembly Absent)

a) The primary (monochromator) slits are removed from the base plate which is then seated inside the casing. A piece of fluorescent screen is set up to register X-rays <u>transmitted through</u> the crystal and, with the X-ray tube operating at half power, the casing is translated past the open window until a broad, luminous area is seen on the screen.

With the crystal bathed in the primary beam, a shadow, due to absorption, is visible on the screen. Throughout the subsequent stages of adjustment, this shadow should be maintained at the center of the illuminated field. This ensures that the rotation axis of the crystal lies on the primary beam axis (see Fig. 7a).

- b) While there are clearly two alternative ways of orienting the crystal in the press, only one is valid owing to the asymmetrical alignment of the (1011) planes relative to the cylinder axis. The prevailing orientation is determined by slowly rotating the press through its angular range and examining the effect on a fluorescent screen, the tube being operated at full power. The incorrect orientation is characterised by the appearance on the screen of a series of thin, bright lines. Removal of the press from its mounting plate, D, and inversion will now yield the correct orientation as demonstrated by the appearance of one or two bright bands on the screen during rotation of the press.
- c) Starting with the arm of the monochromator assembly pointing inwards towards the X-ray anode, rotation away from the tube (increasing $\not{0}$) should yield in turn a bright and a dull, luminous band. These are the α and β components of the X-ray spectrum which are separated by a roughly 1[°] rotation of the press for CuK radiation.
- d) If the X-ray source is correctly located on the circle defined by the curved crystal, the α and β areas will be formed in turn by the coalescence of two separate bands. These move symmetrically towards each other as the wings of the crystal approach the circumference of the circle. This can be understood from Fig. 11. On passing through the reflecting angle, the fluorescent bands meet and then vanish promptly in a vertical direction as the near edge of the crystal passes into, and the far edge leaves the focusing circle. This is the condition to be aimed at for correct location of the crystal.

The presence of only one fluorescent band or the asymmetrical movement of two bands indicates that the distance between the X-ray source and the axis of crystal rotation departs from that specified for focusing (see section 3.2.). Thus, if the beam source lies outside the focusing circle the greatest movement of the fluorescent bands is towards the anode of the tube for a corresponding crystal rotation. The press assembly is translated sideways by steps of 0.5 mm in the appropriate direction and the movement of the fluorescent bands re-examined at each interval until the axis of rotation is correctly located on the focusing circle.

- e) More serious departures from ideal focusing are indicated by striations and irregularities of the luminous area. These may arise from non-uniform stresses in a crystal clamped unevenly in the press, or from a crystal seated so that the cylinder axis does not coincide with the axis of the press. The press should be loosened slightly and the luminous field re-examined. If there is no improvement, slight rotations of the crystal in the plane of the press can be tried.
- f) Assuming that a broad (5 8 mm) band can be obtained on the screen placed one cm from the crystal, focusing of the reflected beam can be examined by moving the screen along the beam axis. With the screen normal to the axis, a fine intense line should be obtained at roughly 140 cm (for CuK α) from the monochromator axis. Inclination of the screen to the beam axis should resolve the $\alpha_1 \alpha_2$ doublet, the weaker α_2 component being nearer the front of the casing (smaller \emptyset).

The crystal may now be locked in position, the fine-threaded screw N (Fig. 8) being used to set the angle of the press against the tension of the retaining spring, M. If the application of tension leads to any asymmetry of the luminous field it can be concluded that the press is too loosely seated and that screw G, on the underside of the slide, needs tightening. Before removing the slide, note its position in the V-block.

WARNING - Owing to the narrowness of the spot in fine-focus Xray tubes, adjustment of the monochromator is exceedingly sensitive and with a good crystal, rotation of the press by a few seconds of arc separates the ideal setting from a non-reflecting position. Play in the moving parts of the monochromator is not permissible, nor is careless handling of the equipment during adjustment. The fine-focus beam is a particular hazard and hands should be kept clear when the beam is admitted into the casing. A further danger is associated with the scattering of secondary radiation from the component parts of the camera, in particular the monochromator. Exposure to this radiation during the adjustment phase can be minimised by laying a plate of lead glass over the open camera when inspecting fluorescent pictures of the X-ray beam. On completion of the adjustment, the monochromator should be covered over with a housing of lead foil carrying a single exit slit, 10 mm square, for the monochromatised beam.

4. 4. Adjustment of the Sample-Film Cassette Assembly

a) The primary slits, P, (Fig. 8) are screwed to the base plate, the vertical elements, Q, being opened to the fullest extent. With fluorescent screens in place, one to receive the primary beam and a second to receive the monochromatized beam, the horizontal elements are moved together with forceps until, on the first screen, only the shadow cast by the crystal remains.

If the luminous field on the second screen exhibits irregular edges, these can be eliminated by further closing the horizontal slits.

The monochromatized beam is now defined sufficiently to permit of setting up the sample holder.

- b) The sample-holder cassette assembly (slits removed) is set roughly in position so that the beam makes an angle ζ of 60 40° with the plane of the sample holder. With a specimen of ZnS in the sample holder, the assembly is manoeuvred in the focusing beam until a vertical fluorescent band appears centrally on the specimen. Maintaining this condition, the cassette is positioned with the primary beam catcher, J, (Fig. 8) open and the metal shutter, L, removed. With a fluorescent screen in place of the film, the passage of the monochromatized beam through the cassette is checked, making small angular displacements of the assembly about the specimen axis. When the beam has been located centrally in the aperture of the catcher, the distance D2 may be set up, moving the assembly along the beam axis.
- c) The assembly is secured in its approximate position by bolts passing through guide slots cut in the supporting plate. A millimetre

scale is fastened against the edge of the assembly plate, parallel to the beam axis.

A standard specimen of lead nitrate (cubic, $a_0 = 7.856$ Å) is next mounted in the camera and with film in the cassette an exposure of fifteen minutes is given. The primary beam is recorded in under two seconds with the tube operating at 12 kV and 6 mA. After developing the film, the sharpness of the reflections is examined at X 20 magnification.

d) The assembly is moved along the beam axis in steps of 1 mm and patterns recorded at each step. With the assembly at the position yielding the sharpest pattern, the secondary (sample holder) slits, T, are inserted and the fluorescent specimen replaced. The vertical slits are closed until the luminous area is roughly 2 mm in height and distributed symmetrically in the vertical sense about the specimen centre.

The horizontal slits are now closed until they just graze the monochromatized beam (ZnS dusted along the edges of the slits serves to indicate their proximity to the beam). The slits may be closed in steps of 0.1 mm, with 15 minute exposures between each step: diffuse bands recorded on the film as a result of diffraction from the metal edges indicate too close a setting.

The luminous area at the centre of the fluorescent specimen should have a horizontal extension of ~1 mm on either side of the centre point.

4.5. Final Adjustment

a) The above steps should yield a sharply defined pattern of lead nitrate over the whole θ range. If the pattern is unsatisfactory, however, the position of the assembly along the beam axis should be re-examined with a series of 0.1 mm adjustments and 15 minute exposures. Failing this, the horizontal components of the primary slits may be closed to obtain a narrower beam, thus irradiating a smaller area of crystal.

- b) Curved tails at the top and bottom of low angle reflections are due to vertical divergence in the primary beam arising from the line focus of the X-ray tube. These are minimized by further closing the vertical elements of the secondary slits or, failing this, the primary slits.
- c) Non-parallel reflections in the pattern of the standard substance arise through a non-parallel condition of the base plate with respect to the primary beam. This effect may be examined by inserting shims under the edges of plate U in turn and recording pairs of patterns which are then placed bottom edge to top edge for comparison. When the correct inclination of the base plate has been found, the appropriate levelling screws are adjusted and the shims removed from beneath the assembly plate.
- d) Extinction of the $K\alpha_2$ component is achieved by increasing the angle between the tube axis and the monochromator arm. The correction required is only about 2 minutes of arc for CuK radiation and should be followed with the aid of 15 minute exposures of the lead nitrate specimen. An approach to the correct condition is marked on the fluorescent screen placed about 2 cm from the crystal by a slight, barely visible, separation between the two luminous bands described in 4.3 c. Over-correction quickly leads to loss of X-ray intensity.
- e) The diffraction patterns of Pb(NO₃)₂ obtained with CuKα₁ radiation should exhibit little or no background darkening after a thirty minute exposure. It is most probable, however, that the low angle region of the photograph will be heavily blackened owing to the presence of parasitic radiation scattered at the monochromator. Removal of this radiation is achieved by inserting shutter S (Fig. 9, 10) into the monochromator press until it just grazes the beam diffracted from the wing nearest to the X-ray tube. This position is found by examining the effect on a fluorescent screen as the shutter is pushed in.
- f) If it is observed that on moving the cassette-specimen holder assembly towards the monochromator, a region of maximum sharpness passes along the pattern, the position of plate H with respect to the specimen holder should be re-examined.

Non-linearity of the relationship between film measurement and diffraction angle arises through missetting of the specimen holder with respect to the recording circle as defined by the diameter of the cassette. Some observations made in connection with this effect are given in 6.3.2.

Measurement of a number of sharply defined patterns of a standard substance can be used to derive an average value for the camera constant defined by

$$\bar{\mathbf{K}} = \frac{\mathbf{l}}{n} \sum_{i=1}^{n} \theta_i / S_i$$

Slight adjustments to the separation of the cassette from the specimen holder and to the angle ζ (4.4 e) can be used to follow the variation of K with θ until a relationship has been obtained which is as nearly linear as possible (see section 6.3.1.).

NOTE - As orginally designed, the Guinier - Hägg camera was operated in vacuo to eliminate background darkening due to the scattering of X-rays by air. Experience so far indicates that this precaution is unnecessary, at least for exposures with a fine-focus tube and $CuK\alpha_1$ radiation. The heavy steel lid to the camera, essential for vacuum operation, has therefore been replaced by a light-weight cover of opaque plastic. There is, accordingly, less risk of disturbance to the critical adjustment of the monochromator from vibrations, which are unavoidably generated on closing the camera with a heavy metal cover. The beryllium window, through which the primary beam was orginally admitted into the camera, has also been removed.

It should be pointed out, however, that the camera design is particularly suitable for vacuum operation, a feature which is essential to powder photography with longer wavelength radiation, such as CrKa.

5. EXAMINATION OF POWDER SAMPLES IN THE GUINIER - HÄGG CAMERA

5.1. Specimen Treatment

Normally, powder patterns are obtained from specimens dusted onto an adhesive plastic tape stretched over a thin brass diaphragm. Care should be taken to obtain a thin (<30 μ), uniform layer of powder to ensure X-ray transparency and the sharpest possible definition for the focused reflections. A simple rule of thumb is that, with the brass diaphragm held up against the light, the powder sample, crushed to >200 #, should still transmit light without appearing unduly patchy in a 2 x 2 mm central region.

Due to the monochromatic character and focusing of the X-ray beam, uniformly smooth reflections are obtained with crystallites having sizes apprecially greater than those tolerated in a D - S specimen. This is clearly demonstrated in the patterns of BaCl₂. $2H_2O$ shown in plate II. The D - S pattern exhibits marked graininess due to diffraction from crystallites larger than 20 μ . For the same specimen treatment the G - H pattern is comprised of the customary sharp reflections. In this connection it has been possible to obtain sharp G - H patterns from thin alloy foil specimens which, after heat treatment demonstrated crystal sizes of 40 - 50 μ .

Crystalline samples in the form of well developed needles constitute the most serious hazard as regards irregularity of the specimen, since a fraction of the needles will tend to "hedgehog" from the surface of the tape producing streaky and uneven reflections. While smoothing the sample with a fine spatula achieves uniformity, the powder will tend to exhibit preferred orientation with a consequent weakening or even extinction of some reflections and artificial strengthening of others. A laborious but effective method of combating this phenomenon is to mix the powder with a small quantity of a plastic cement which becomes brittle on drying. Regular cleavage is not a property of such material and crushing in a mortar will reduce the brittle mass to irregularly shaped fragments.

A tape recommended for use in sample preparation is marketed by 3Ms under the trade name Magic Mending Tape. This has a base which retains its planarity on stretching and gives a low background, uniform over the whole θ range even on prolonged (4 hour) X-ray exposures.

5.2. Encapsulated Materials

Materials sensitive to moisture or air (deliquescent, hygroscopic or pyrophoric compounds) or materials with which a health hazard is associated, can be handled in thin plastic envelopes, circularly shaped to fit the specimen holder. Powder is first dusted over an area of tape and a circle of 3 mm radius is punched out. The circle is then inserted, with the help of forceps, into a bag of thin transparent plastic, the specimen being maintained in a planar condition be feeding it through a wide-bore, glass or perspex tube. The specimen is then sealed in with an annular weld, at least 3 mm wide, taking care not to heat the powder-coated area. (If HF heating is employed to make the weld, the specimen can be positioned between two recessed metal formers, the powdercoated area being located within the recess.) A disc of appropriate diameter can now be punched from the sealed envelope and mounted between two brass diaphragms for exposure in the focusing camera.

Guttagena foil, from which the envelopes can be prepared, is obtainable from Kalle AG, Wiesbaden-Blebrich, Germany. Plastic of thickness 0.08 mm, (grade T62 transparent, glossy) is sufficiently durable to be formed into large bags from which envelopes for a number of specimens may be prepared. Exposure times are roughly trebled with this material and, as might be expected, diffuse bands appear in the low-angle area of the diffraction pattern. General background scattering is not significantly increased, however.

The G - H method is not ideal for the most chemically unstable materials since it demands a specimen in the form of a thin film which implies the existence of a large surface area for the air - or moisturesensitive powder. For this reason it is essential to preserve lengths of tape, stretched on perspex blocks, and small plastic bags, dilated on wire cages, in the dehydrating atmosphere of a vacuum desiccator.

5. 3. Fluorescent Specimens

All materials fluoresce, to some extent, on irradiation with X-rays giving rise to a background continuum upon which the diffraction pattern is superimposed. Strict monochromatization affords almost complete elimination of this background except for materials containing elements excited by the chosen X-ray component. One solution to this problem is to replace the film with a scanning electronic detector fitted with a second monochromator. A simpler solution consists in screening the diffracted radiation through a thin aluminium foil inserted in the window of the film cassette, a narrow opening being left to permit passage of the primary, monochromatized beam. Foil of 0.03 mm thickness is completely effective with compounds of the rare-earth and actinide elements and even permits photography of patterns from iron- and cobaltcontaining compounds with $CuK\alpha_1$. Exposures are increased roughly two-fold and the high-angle reflections are disproportionately weak-ened by absorption in the foil.

6. EVALUATION OF THE GUINIER - HÄGG CAMERA AS AN ANALYTICAL INSTRUMENT

6.1. Exposure Times and General Sensitivity

A G - H camera, properly adjusted for the focusing of strictly monochromatic $CuK\alpha_1$ radiation, gives high quality powder patterns over the full recording range up to $45^{\circ}(\theta)$. The photographs reproduced in plates I and II are representative of the patterns of well crystallised materials examined in these laboratories during the past three years. The D - S patterns of the same materials, reproduced for comparison purpose, were obtained using the line focus of the same type of fine focus X-ray tube.

It will be seen that even with $K\alpha_1$ radiation alonë the exposure time for a Guinier pattern is roughly one sixth of that for the corresponding D - S pattern. Moreover, the G - H pattern is roughly ten times more sensitive to the detection of weak reflections, owing to a combination of the greater intensity of the incident beam in relation to the area of sample irradiated, the focusing of the diffracted rays and the low rate at which the peak/background ratio falls with exposure time.

Independently of the type of camera employed, specimens with a high transparency to X-rays and a composition based on strongly scattering atoms can be expected to yield the shortest exposure times. This is the case so long as the available diffracted intensity is concentrated to a small number of reflections as in the cubic phases tungsten and the dioxides of uranium or thorium. With increasing pattern complexity, exposures lengthen and it may be necessary to overexpose the principal reflections in order to reveal the fainter lines, if these are of significance. This is often the case, for example, in phase analysis.

For X-ray film, the blackening curve is roughly linear, the intensity of a reflection increasing proportionally with time. If the first visible evidence of a reflection is taken to represent an intensity of one, the maximum registerable intensity is of the order of 180. Beyond this point, the reflections only increase in width. Below are listed some typical minimum and maximum exposure times between which G - H patterns have been fully registered without demonstrating line broadening due to over-exposure. The film used was Ilford Industrial G which affords a good balance between speed and line definition. The patterns were obtained with $CuK\alpha_1$ radiation.

Specimen	No. of reflections	Min. time (mins)	Max.time (mins)
Silicon	6	10	25
Black P	18	30	90
Pb(NO ₃) ₂	19	8	20
υ0 ₂	9	<5	15

As an extension of this study, the sensitivity of the G - H camera in phase analysis was tested by photographing various mixtures of well crystallised UO_2 and ThO_2 which have comparable scattering properties for X-rays. The samples were made up by first ball milling the powders in a weight ratio for UO_2/ThO_2 of 10/1. This mixture was successively diluted with futher additions of UO_2 and ball milled to ensure homogeneity. In this way 500 g mixtures of ThO_2 in UO_2 were obtained at dilutions of 1%, 0.5%, 0.1%, 0.05% and 0.01%. The samples were exposed in the focusing camera and the times taken to register the 111 and 200 reflections of ThO_2 were recorded. Specimens of these mixtures were also exposed in a powder diffractometer in order to provide a control of the peak heights of the 111 reflections from both ThO_2 and UO_2 . For this purpose the 111 peaks and the adjacent backgrounds at $\pm 4^{\circ}$ (20) were also step-scanned using a step length of $0.02^{\circ}(20)$.

	Guinier-Hägg-patterns		Powder diffractometer			
Dilution	Exposure times (mi- nutes) in which prin- cipal ThO ₂ reflections are visible		Peak height counts for 111 reflections in		$\frac{\text{Peak ratios}}{111 \text{ ThO}_2}$ $\frac{111 \text{ UO}_2}{111 \text{ UO}_2}$	Back- ground counts
$\frac{100}{1002}$	111	200	ThO ₂	υ0 ₂		
1	30	120	2150	22056	0.97	158
0.5	60	200	2325	45789	0.51	289
0.1	200	950	842	88956	0.9 ₅	589
0.05	950	Not visible	385	87601	0.43	600
0.01	Not visible	Not visible	Not visible	90010	J	610

From the above results it is clear that for phases of comparable scattering power, the detection of one component of a phase mixture is guaranteed at the 1% level for a normal G - H pattern exposure. For prolonged exposures, detection is possible at the 0.1 - 0.05% level. The sensitivity is in this respect comparable to that obtained in a powder diffractometer operated under step-scan conditions, with the difference that the diffractometer result is quantitative. In both instruments the 0.01% dilution yields no visible trace of the weaker phase owing to interference from the background. These results are comparable to those obtained by Parrish and Taylor for diffractometer ter scans of silicon in LiF [15].

In less favourable cases where the minor phase scatters more weakly or is in a poorly crystalline condition the sensitivity of the Xray method is clearly reduced and contents as high as 10 - 20% may be undetectable.

6.2. Treatment of Diffracted Intensities

By comparison with the powder diffractometer, the G - H camera is a generally less satisfactory instrument for recording diffracted intensities, largely owing to the limitations of the photographic method. The sharpness of the focused reflections necessitates scanning by a microdensitometer which provides a light beam of 0.5 mm maximum width or even smaller. This requirement is in conflict with the need to employ as large a slit width and height as possible in order to minimize the effects of film graininess. Possible solutions to this problem are

- a) to defocus the X-ray beam slightly by displacing the specimen from the plane tangential to the film circle. The loss of resolution consequent upon the resultant broadening of the reflections could be compensated by using a film cassette of 50 % greater radius.
- b) to replace the film by a step-scanning proportional detector, fitted with a 1[°] receiving slit which moves along the focusing circle.

The correction of intensities recorded with monochromatic radiation must take account of the polarization of the incident beam by the monochromating crystal. The combined Lorenz, polarization, oblique
incidence and absorption corrections have been given by Hägg [16] as follows:

$$M = \frac{1 + \cos^2 2\theta_m \cos^2 2\theta}{\sin^2 \theta \cos \theta} \cdot \frac{1}{\cos (2\theta - \alpha)} \cdot \exp \left(-\frac{\mu t}{2\theta \cos (2\theta - \alpha)}\right)$$
$$\left[1 - \exp \left(\frac{-\mu_f h}{\cos (2\theta - \alpha)}\right)\right]$$

where

 θ = Bragg angle for reflection hk ℓ

 θ_{m} = glancing angle for monochromator crystal (13.21° for Cuk α_{l} and quartz 1011 planes)

$$\alpha = 90 - \zeta$$
 = angle between axis of monochromatic beam and nor-
mal to plane of specimen

$$\mu$$
 = absorption coefficient of specimen

 $\mu_f =$ absorption coefficient of film emulsion

- t = thickness of specimen
- h = thickness of emulsion layer

For thin specimens and high to medium X-ray transmission the above expression can be approximated to

$$M = \frac{1 + \cos^2 2\theta_m \cos 2\theta}{\sin^2 \theta \cos \theta} \cdot \frac{1}{\cos(2\theta - \alpha)}$$

The relationship between the observed Guinier intensity and the structure factor is in any case given by

$$I_{Obs} = C.M.p. |F_{hk\ell}|^2$$

where

I_{Obs} = observed intensity

- C = proportionality constant depending upon exposure time for a given specimen
- M = trigonometrical factor defined above

 $F_{hk\ell}$ = structure factor

An account of the solution of the $Sr(OH)_2$. OH and $Sr(OH)_2$ crystal structures using G - H intensity data will be given separately.

6.3. Pattern Definition, Calibration and the Measurement of θ

6.3.1. Precision of Film Measurement

The G - H film cassette records the powder pattern only up to 45 - 50° (θ). Although, as indicated in section 2.4, this angular region is not ideal as regards the precision for obtaining $d_{hk\ell}$, the loss by comparison with high angle (> $60^{\circ}(\theta)$) D - S measurements is largely offset by the greater ease with which intensity maxima are located. Thus the film geometry of the G - H camera gives a relationship between the Bragg angle and the film measurement S of

$$(\theta/S)_{C-H} = 45/\pi R \text{ deg arc mm}^{-1}$$

For D - S film geometry

 $(\theta/S)_{D-S} = 90/\pi R \text{ deg arc mm}^{-1}$

or a factor of two greater than that for the G - H camera with the same film radius. Furthermore the focusing action of the G - H camera limits the width of medium strength reflections to 0.04 - 0.05 mm; the intensity maximum can generally be located to within 0.01 mm. In the 80 mm diameter cassette this corresponds to a precision of $0.0035^{\circ}(\theta)$. In addition the use of strictly monochromatic radiation eliminates the risk of errors in θ due to the overlap of peaks of different wavelength. Under these conditions it has proved possible to resolve the peaks of reflections which are separated by as little as $0.03^{\circ}(\theta)$.

The patterns reproduced in plates I and II demonstrate the difference in line definition to be expected as between D - S and G - H patterns. For simple materials in a well crystallised condition, such as silicon, the D - S patterns beyond $60^{\circ}(\theta)$ is well developed and a high precision in the measurement of θ can be expected. For the majority of materials, however, such as minerals, alloys, complexes and other compounds with low symmetry structures or less favourable elastic properties, the D - S patterns are as those represented by black phosphorous, U_3O_8 or BaCl₂. $2H_2O$. In these instances the high pattern definition and good resolution of the G - H films clearly offers the only real chance of obtaining reliable readings of θ . It should be pointed out here that the width of the reflections in both types of pattern has been increased in the process of photographic reproduction.

6.3.2. The Camera Constant and the Origin of Systematic Errors in the Measurement of θ

The value of the camera constant

 $K = \theta/S$

should be obtained as mentioned in section 4.5 f for a number of reflections using a specimen for which the cell dimension is known to within ± 0.0001 Å. It will then be found that for the 80 mm diameter cassette, K departs in a systematic fashion from the expected value of 0.3581 over the whole angular range. The departures should be small (<1 %) for a well adjusted cassette and an average value of K can be used for most purposes. Thus a value of 0.3576 has been used in the present instance to construct a scale for the direct reading of interplanar spacings in G - H patterns. The values of d so obtained are of acceptable accuracy for use in phase identification with the ASTM Index to the Powder Diffraction File.

The variability of K with θ is generally attributed to the approximation to ideal focusing geometry in the arrangement of specimen and film cassette. Thus a linear relationship between θ and S in the focusing camera is only possible when the specimen corresponds over all its length with the recording circle. In practice, the specimen is at best at a tangent to the circle and may in fact be displaced from it. A major factor in producing variations in K is the departure from 90° in ζ , the angle between the incident monochromatised beam and the plane of the specimen.

Möller [17] has analysed the effects of specimen displacement ε from the tangential plane for different values of ζ and derived a parameter E to describe the relative camera constant K, (see Fig. 8a).

$$E = \frac{\Delta K}{K \cdot K_{o} \cdot \epsilon} = \frac{1}{\theta} \cdot \frac{\sin 2\theta}{\cos \zeta \cdot \cos (2\theta - \zeta)}$$

Variations in the camera constant K over the observable θ range are shown in Fig. 12a for -0.67 $\leq \varepsilon \leq 0.04$. Curves for E with $\zeta = 70^{\circ}$, 55° and 45° are given in Fig. 12b. From these, it is seen that values of K_{θ} over the diffraction range are most reliably interpolated from a set of calibration points when $\zeta = 55^{\circ}$. At $\zeta = 45^{\circ}$ changes in E occur most rapidly at $\theta < 20^{\circ}$ but are only small at $35 < \theta < 50^{\circ}$; this inclination is therefore most appropriate if measurements at the higher Bragg angles are desired.

6.3.3. Calibration of G - H Patterns

There is considerable difficulty in measuring ε and in maintaining a constant value for the specimen displacement from exposure to exposure. Accordingly, accurate values of $\theta_{hk\ell}$ are most readily obtained from the Guinier patterns by including an internal calibrant in the Xray specimen and referring all readings of $S_{hk\ell}$ to the curve of $K(\theta)$ obtained for calibrant reflections.

Requirements for the calibrant are as follows:

- a) It should give between five and eight reflections over the diffraction range, the last reflection lying within a few degrees of θ max for the film.
- b) The diffraction angles for the calibrant reflections should be known to within 10% of the standard deviation estimate for the film reading. This is most easily achieved if the calibrant is a cubic material which can be readily obtained in pure form.
- c) It should be chemically and physically stable and be hard and brittle so that crushing in a mortar and mixing with the specimen do not lead to detectable line broadening or other changes of pattern.

Semiconductor grade (>99.999% purity) crystals of silicon comply with these requirements, six calibration points being afforded with CuK α radiation, the last at 44.015°(θ). The cell dimension of high purity silicon has been determined by a number of investigators to be 5.43062 ± 3 Å at 25°C [18]. The coefficient of linear expansion is 22.5 \cdot 10⁻⁶ Å deg⁻¹ so that variations in the quoted cell dimension at the \pm 0.0001 Å level can be ignored for a camera maintained at 23 \pm 3°C. Finally, silicon can be crushed to a powder with particle sizes less than 50 μ without evidence of line broadening. Calibration data for silicon with CuK α_1 radiation are given in Table 1.

6.3.4. Film Measurement and Derivation of K

After the variability of K with θ , the main systematic error associated with the measurement of G - H patterns results from film shrinkage on developing and fixing. According to Hägg, shrinkage errors are minimized by printing a 0.1 mm graduated scale on the exposed film before developing [19]. This has the advantage over the use of fiducial marks of eliminating errors due to non-uniform shrinkage. For measurement purposes the patterns and attendent scale are enlarged (X 30) and read with a 0.01 mm vernier. For a well defined pattern, with reflection widths of the order of 0.05 mm, the peak positions of silicon calibrant reflections can be estimated to within \pm 0.01 mm in successive readings.

A calibration curve of K versus θ can be constructed from the measured values of S_{Si} and the tabulated θ_{Si} values and drawn on millimetre paper to facilitate the derivation of K_{θ} for any interval S. Examples of some values of K for silicon in four different specimens are given in Table 2.

A more rapid and objective approach to obtaining K is afforded by computer methods. Thus a second degree Legrange interpolation can be used to derive K for values of S between the calibration points. This is the basis of the programme MOTT which has been incorporated as a preliminary step in larger programmes for indexing powder patterns and refining cell dimensions from G - H pattern measurements.

The camera constant K_{θ} at an interval XP from the trace of the primary reflection is obtained by a cumulative procedure which takes account of three, adjacent calibration points K_1 , K_2 , K_3 at intervals X_1 , X_2 and X_3 .

Then

$$K = K_{1} \frac{(XP-X_{2}) (XP-X_{3})}{(X_{1}-X_{2}) (X_{1}-X_{3})} + K_{2} \frac{(XP-X_{1}) (XP-X_{3})}{(X_{2}-X_{1}) (X_{2}-X_{3})} + K_{3} \frac{(XP-X_{1}) (XP-X_{2})}{(X_{3}-X_{1}) (X_{3}-X_{2})}$$

Calculations show that for curves of the quality given in Table 2, the error in θ resulting from this interpolation is less than 10% of the random measurement error in θ . A listing of the MOTT programme written in FORTRAN IV for the IBM 360/30 computer at Studsvik is given in the appendix.

General experience shows that observation of the following points serves to keep the influence of systematic errors to a level below that of the random measurement error.

- a) The graduations on the printed scale are aligned parallel to the Xray reflections.
- b) Calibrant reflections should be sharp and clearly resolved, and for silicon, the last five reflections in patterns obtained with CuKα radiation should not exceed medium intensity.
- c) The CuK α_2 component should be absent, particularly if the cassette is in the parallel position (section 3.1.).
- d) Background scattering should be less than one-tenth of the medium strength intensities.
- e) For broadened reflections, θ is obtained from the averaged readings of the low and high angle edges of the line.
- f) The calibration curve should preferably be smooth and as nearly linear as possible $(dK/d\theta < 10^{-4} \text{ mm}^{-1})$.
- g) If for any reason, remeasurement of reflections becomes necessary, the whole pattern should be remeasured.

6.3.5. The Magnitude of Residual Systematic Errors in θ

If it can be assumed that systematic errors in G - H film measurements can be reduced to negligible proportions by employing an internal calibrant and comparing the reflections with a scale printed on the film, the dominant error is the random error associated with the location of the reflection maxima. The total random error in a measurement at $30^{\circ}(\theta)$ can be expected to produce at most an error of 0.01% in the determination of $d_{hk\ell}$, or 0.005 Å in the measurement of a 5 Å cell dimension. For a D - S pattern, the accuracy obtainable at this angle is probably not better than 0.2% owing to absorption in the specimen and eccentricity in the specimen/camera geometry. If the D - S pattern, for any of the reasons listed in 2.3 and 2.4, lacks definition beyond this angle, the removal of systematic errors is virtually impossible and the uncertainty in the final results is considerable. Evaluation of θ from the G - H film, using the procedure described above, is therefore more consistently reliable, since it contains errors more closely relatable to the absolute error in θ than is the case with the D - S pattern.

The systematic errors which remain in the G - H measurements are limited to the uncertainty in the wavelength of the radiation used and the cell dimension of the calibrant. The wavelength of $CuK\alpha_1$ radiation is one of the most accurately determined X-ray constants. Quoted in Å units, however, it is given as 1.54051 ± 6 [20] owing to the uncertainty in the factor relating the Å and KX units employed for the practical measurement of X-ray wavelengths. In order to avoid confusion, therefore, it is generally recommended that where values of $d_{hk\ell}$ or cell dimensions are derived from measurements of θ , the value of the wavelength used should be given. Similar practice extends to the quoting of the unit cell dimension of the compound used in calibrating the G - H pattern.

6.4. Unit Cell Dimension from Guinier - Hägg Film Measurements

6.4.1. Evaluation of Cell Dimensions and their Probable Errors

For powder reflections with known Miller indices values of $\theta_{hk\ell}$, obtained from film measurements as described above, can be used to derive the dimensions of the crystallographic unit cell. For this purpose the θ values are converted to corresponding values of Q (= $4 \sin^2 \theta / \lambda$) and employed in the linear equation appropriate to the cell symmetry given in Table 1. Where the evaluation of more than one coefficient from a number of different $\theta_{hk\ell}$ is entailed, it is convenient to employ the method of least squares in accordance with the approach originally suggested by Cohen [9]. The function, R, to be minimized is formed from the

differences ΔQ between observed values of Q and the values calculated from the coefficients. Then

$$R = \sum_{i=1}^{n} \omega_i (\Delta Q_i)^2$$

where w_i represents a weighting term for Q_i , based on the reliability of the measurement of θ_i .

The advantage of G - H data in this context is that they are free from large scale systematic errors which reduce the value of least squares calculations. Measurement of all the reflections in the pattern can therefore be employed to obtain a statistical distribution of the measurement errors. In this way the probable error can be reduced to a level considerably below that for the single reflection measurement described in the preceding section.

It is assumed that the calibration procedure reduces the systematic error in θ to a level below the random measurement error. The weighting scheme proposed by Hess [27]

$$\omega_i = 1/\sin^2 2\theta_i$$

based on the natural variation in the precision of d as a function of θ (section 2.4.) can therefore be used with G - H data.

The least squares calculation is most conveniently performed with a computer and a programme MOTT-CELL has been devised for this purpose. In this programme the elements of the normal equations are formed from the linear expressions for Q by partial differentiation with respect to the parameters a_0 , b_0 , c_0 etc. Values of the corrections Δa , Δb , Δc etc. are obtained iteratively, the process being carried out to convergence. Since the diagonal elements of the least square matrix contain the partial derivatives $\partial Q/\partial a$, $\partial Q/\partial b$, $\partial Q/\partial c$ etc. standard deviations for the general cell parameter a_j can be calculated according to conventional statistical practice [22].

$$\sigma_{a_j} = R.A'_{jj}/N$$

where

N = number of degrees of freedom (number of G_i employed (n)-

number of parameters to be determined (q)).

$$R = \sum_{i=1}^{n} \omega_i (\Delta Q_i)^2$$

A'_{jj} = diagonal element of the inverted matrix corresponding to parameter a_i.

Computer print-outs of G - H diffraction data treated in this way are given in Appendix II by way of example. The compounds chosen range from cubic UO_2 and ThO_2 which afford patterns with only a few reflections to monoclinic $BaCl_2$. $2H_2O$ with a line-rich pattern of 132 measurable reflections. Inspection of the lists of $\Delta \sin^2 \theta$ given in the print-outs shows that discrepancies are generally less than $5 \cdot 10^{-5}$ while the standard deviations of the cell dimensions are 0.005% or better.

6. 4. 2. Significance Tests for Residual Systematic Errors

In order to test the correctness of the calibration and interpolation treatment for obtaining θ from film measurements, significance calculations have been made on the Bragg-angle data used to calculate cell dimensions as described above.

The difference Δ between the observed and calculated values of $\sin^2 \theta$ is used in the least squares treatment as a measure of the approach to the probable cell dimensions. Measurement of n reflections in the powder pattern represents n independent estimates of the cell dimensions required to define the pattern. The self consistency of these n values of Δ is accordingly an indication of the probable correctness of the dimensions; a transition from large negative values of Δ for low θ reflections to large positive values of Δ for high θ reflections should therefore signify the operation of a systematic error in the derivation of θ . If the discrepancies Δ are compared over the whole angular range of the pattern with an estimate of the random error in the measurement of θ , a measure is obtained of the degree to which the angular dependent systematic errors are removed. This is the basis of the LRM or Likelihood <u>Ratio Method developed by Beu [23]</u> who uses the chi-squared distribution method for testing hypotheses, as follows.

The standard deviation estimate of the average θ value for the ith reflection is calculated using the conventional expression

$$\sigma_{\theta}^{2} = \frac{1}{p} \sum_{n=1}^{p} (\bar{\theta} - \theta_{n})^{2}$$

where

 $\sigma_{\theta} = \text{ the standard deviation of } \theta$ $\theta_{n} = \text{ the nth measurement of } \theta \text{ for th ith reflection}$ $p = \text{ the total number of measurements of } \theta_{i}$ $\bar{\theta} = \text{ the average value } \frac{1}{p} \sum_{n=1}^{p} \theta_{n} \text{ for p measurements of } \theta.$

A function $W(a_0)$ has been derived to measure the probability of the cell dimensions from a comparison of the estimates of σ_{θ_i} and the differences between observed and calculated values of θ_i according to

$$W(a_{0}) = \sum_{i=1}^{n} p_{i} \ln \left[1 + (\Delta \theta / \sigma_{\theta})_{i}^{2}\right]$$

where n represents the number of θ_i employed.

Calculation of $W(a_0)$ for a range of cell dimensions in the neighbourhood of the values obtained by the least squares method leads to the realisation of a minimum W_m which corresponds to the most probable dimensions a_m , b_m , c_m etc. W_m is a statistical function used to determine whether or not systematic errors have been removed from the data within the precision of the measurement. For this purpose W_m is compared with W_e , a value of the chi-square distribution for N degrees of freedom at the 5% significance level [24]. If $W_m < W_e$, θ dependent systematic errors are assumed to be absent within the precision of the measurement. The values a_m , b_m , c_m etc. are accordingly cell dimensions which satisfy the hypothesis of "no remaining systematic errors".

A programme LIRIC for Likelihood Ratio Calculations has been devized by the writer to compute $W(a_0)$ for symmetries up to and including orthorhombic. Values of the cell dimensions are taken at intervals of $5 \cdot 10^{-5}$ Å on either side of the least squares results and $W(a_0)$ is calculated at each interval with $0.003^{\circ} < \sigma_{\theta} < 0.004^{\circ}$ for three readings of θ_i . Table 4 gives a comparison of the LRM cell dimensions for UO_2 , Pb(NO₃)₂, α -Fe₂O₃ and α -SiO₂ and the corresponding least squares values together with the W_{ϵ} value taken at the 5% significance level and

the interpolated value of W_m . The standard deviations at the 95% confidence level of the dimensions are calculated in LIRIC using the expression

$$\sigma_{a_j} = 1.96 \cdot a_{m_j} / (\sum_{i=1}^{n} p_i \tan^2 \theta_{m_i} / \sigma_i^2)$$

where

The results in Table 4 are given for a cassette with the generally recommended $\zeta \% 55^{\circ}$ setting and also for a cassette with $\zeta = 70^{\circ}$. In the first of these settings differences between the least squares and LRM cell dimensions are insignificant, being roughly one-tenth of the standard deviations. In all cases the test $W_m < W_e$ for the removal of θ -dependent errors is satisfied at the 5% significance level.

For the second setting where only five silicon reflections are available to define the calibration curve (c. f. Table 3), the results are less satisfactory. The LRM values are consistently greater than the least squares values by $3 - 5 \cdot 10^{-4}$ Å. These discrepancies are covered, however, by the standard deviations which are appreciably larger than those for the $\zeta = 55^{\circ}$ setting. With the exception of UO₂, the values of $W_{\rm m}$ exceed $W_{\rm c}$ by more than a factor of two, indicating the presence in the data of residual systematic errors.

From the agreement between the least squares and LRM results for $\zeta = 55^{\circ}$, it is reasonable to assume that G - H patterns are capable of yielding cell dimensions with 0.005% accuracy. It is clear, however, that the effectiveness of calibration procedures should be tested before placing full confidence in the results of least squares calculations. In this connection the approach afforded by the LRM calculations appears to be an effective means of testing calibration reliability. In order to demonstrate the reliability of the G - H powder data, cell dimensions for a number of the compounds listed in Appendix II are compared in Table 5 with values quoted in the literature. Only those materials with an acknowledged freedom from variations in stoichiometry were chosen for this comparison. Thus cubic ThO₂ has been selected rather than UO_2 , CeO_2 or PuO_2 , each of which is a member of a binary solid solution.

The agreement between the G - H and literature results is significant, particularly in the case of the cubic phases where the errors are concentrated to a single parameter. In this connection, the value for Pb(NO₃)₂ was remeasured using a D - S camera in view of the large σ_a of 6.10⁻⁴ Å given in the literature. The D - S measurements were refined with the MOTT-CELL programme introducing additional terms in the linear equation for Q_{hkl} to account for specimen eccentricity and absorption [25]. The D - S results for black phosphorous were obtained using CrK α radiation, the pattern with CuK α radiation being indistinct beyond 35^o(θ) (see plate I). The graphical Nelson - Riley treatment of the data which led to the published results has since been checked using the MOTT-CELL programme. The revized values of the cell dimensions agree with the published values within the limits of the standard deviations.

The results obtained for $BaCl_2$. $2H_2O$ are particularly striking in view of the quality of the D - S film which is clearly quite unsuitable for measurement (Plate II). The literature values are based on the precise measurement of twelve hkl reflections using a single crystal diffractometer. The G - H pattern which contains 132 measurable reflections was indexed on a probability basis using the programme PIRUM devized by P.E. Werner of the Department of Inorganic and Physical Chemistry, University of Stockholm. Of the listed reflections only three yield differences $\Delta \sin^2 \theta$, which exceed $2 \cdot 10^{-4}$.

7. APPLICATIONS

The short exposure times (15 - 30 minutes), sharp line definition (< 0.05 mm) and large effective film diameter (16 cm) make the G - H camera ideal as an instrument for rapid phase analysis of materials available as homogeneous powders. Since only microgramme quantities

of sample are required, the method is particularly suited to the analysis of small amounts of material. The D - S method is only superior when it becomes necessary to study, in situ, coatings on fragments of material or inclusions in transparent media such as glass.

The accuracies obtained for cell dimensions by routine treatment of the powder data facilitate the study of solid solubility effects in phases with low symmetry and/or large unit cells. The good resolution at low Bragg angles permits a high degree of sensitivity for the detection of line splitting, indicative of a reduction in crystal symmetry, which can accompany the formation of a solid solution or a defect compound. The level of accuracy, which is generally better than 0.01 %, is adequate for most analytical work involving the solubility of small amounts of material. Powder diffractometer and D - S results are only superior in the relatively limited context of detecting variations in lattice spacings at the 0.001 % level in well-crystallized materials with high symmetry.

Where powder patterns of hitherto unreported phases are recorded it is often desirable to determine the cell symmetry and space group in order to make possible a comparison with established compounds. For this purpose, it is necessary to determine the hkl indices of the constituent reflections of the pattern, a process which depends upon the occurrence of specific relationships between the values of $\sin^2\theta$ for the different symmetry classes. Since low-angle reflections have the simplest indices, often of the form 100, 010, 002 etc., the various trialand-error indexing methods which have been devized are largely based on assumed values for the indices of these reflections. G - H powder data is particularly suited to this type of treatment in view of the close correlation between values obtained for the cell dimensions using lowangle data and those derived from data in the 30 - $45^{\circ}(\theta)$ region. In this connection only diffractometer data is of comparable quality while measurements of D - S films have in the past led to many spurious indexings.

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LINEAR EQUATIONS FOR THE RELATIONSHIP BETWEEN BRAGG ANGLE, MILLER INDICES AND UNIT CELL PARAMETERS FOR MONOCLINIC TO CUBIC SYMMETRIES

 θ = Bragg angle; λ = radiation wavelength; hk ℓ = Miller indices; a, b, c = cell dimensions; β = angle between a and c axes; $Q_{hk\ell} = 4 \sin^2 \theta_{hk\ell} / \lambda^2$

MONOC LINIC $\alpha = \gamma = 90^{\circ} \neq \beta$ $a \neq b \neq c$	$Q_{hk\ell} = Ah^2 + Bk^2 + Cl^2 + Dh\ell$	$A = 1/a^2 \sin^2 \beta$	$B = 1/b^2$	$C = 1/c^2 \sin^2 \beta$	$D = -2\cos\beta/ac\sin^2\beta$
ORTHORHOMBIC $\alpha = \beta = \gamma = 90^{\circ}$ $a \neq b \neq c$	$Q_{hk\ell} = Ah^2 + Bk^2 + Cl^2$	$A = 1/a^2$	B=1/b ²	$C = 1/c^2$	-
TETRAGONAL $\alpha = \beta = \gamma = 90^{\circ}$ $a = b \neq c$	$Q_{hk\ell} = A(h^2 + k^2) + C1^2$	$A = 1/a^2$	-	$C = 1/c^2$	_
HEXAGONAL $\alpha = \beta = 90^{\circ}, \gamma = 120^{\circ}$ $a = b \neq c$	$Q_{hk\ell} = A(h^2 + hk + k^2) + Cl^2$	$A = 4/3a^2$	-	$C = 1/c^2$	-
CUBIC $\alpha = \beta = \gamma = 90^{\circ}$ a = b = c	$Q_{hk\ell} = A(h^2 + k^2 + \ell^2)$	$A = 1/a^2$	-	-	-

CALIBRATION DATA FOR SILICON POWDER

 $a_{0} = 5.43062 \pm 5$ Å at $25^{\circ}C$; $\alpha_{T} = 22.5 \cdot 10^{-6}$ Å deg⁻¹ C; $\lambda CuK\alpha_{1} = 1.54051$ Å (assumed as basis for calculation)

h	k	e	$\sin^2 \theta$	θ
1	1]	0.060352	14.2212
2	2	0	0.160939	23.6514
3	1	1	0.221291	28.0612
4	0	0	0.321877	34.5651
3	3	1	0.382229	38.1882
4	2	2	0.482816	44.0152
3	3	3	0.543168	47.4764

CAMERA CONSTANTS AND THEIR DEVIATIONS OBTAINED WITH SILICON CALIBRANT FOR 80 MM DIAMETER CASSETTE

 ζ is angle between axis of incident beam and plane of specimen; $\sigma(s)$ is error in K produced by an error in film measurement

of ± 0.01 mm

 $\sigma(\theta)$ is error in K produced by error in silicon cell dimension of ± 0.0001 Å.

	K									
	ζ ⁰ hkl	111	220	311	400	331	422	333		
	70	0.35492	0.35498	0.35499	0.35514	0.35492	-	-		
	70	0.35518	0.35503	0.35499	0.35485	0.35475	-	-		
	55	0.35816	0.35809	0.35805	0.35812	0.35821	0.35830			
,	55	0.35788	0.35769	0.35767	0.35765	0.35763	0.35764	-		

σΚ							
୍ର(s)	0.00011	0.00005	0.00004	0.00004	0.00003	0.00003	
σ(θ)	0.00008	0.00008	0.00007	0.00007	0.00007	0.00006	

COMPARISON OF CELL DIMENSION CALCULATIONS FROM GUINIER - HÄGG DATA USING LEAST-SQUARES AND LIKELIHOOD-RATIO METHODS

	In the second		the second s				and the second
		UO ₂	Pb(NO ₃) ₂	a-Fe203		α -SiO ₂	
		a o	a o	ao	с _о	ao	с _о
	Least squares	5.4706	7.8552	5.0351	13.7515	4.9124	5.4045
	Result	± 3	± 1	± 1	± 5	± 1	± 3
$\zeta = 55^{\circ}$							
	LRM	5.4706	7.8551	5.0351	13.7514	4.9125	5.4048
	Result	± 3	± 3	± 2	± 5	± 2	± 2
	N	8	19	14	1	2	1
	Wm	4.54	17.58	13.	13	30.	02
	We	15.51	30.14	23.68		32.67	
	Least squares	5.4696	7.8545	5.0374	13.757	4.9147	5.4040
	Result	<u>+</u> 3	· ± 8	± 4	±Ι	<u>+</u> 2	± 3
$\zeta = 70^{\circ}$							
	LRM	5.4697	7.8551	5.0377	13.758	4.9149	5.4043
	Result	± 4	± 6	± 3	± 1	± 2	± 3
	Ν	7	16]	1	2	0
	Wm	14.05	63.21	50.51		72.51	
	Ψ _ε	14.07	26.30	19.68		31.41	

Cell Dimensions in Å based on following assumptions:

 $\lambda CuK\alpha_1 = 1.540510 \text{ Å}$ a₀ (S_i) = 5.43062 Å at 23^oC.

COMPARISON OF CELL DIMENSIONS FROM GUINIER -HÄGG DATA WITH LITERATURE VALUES

Phase	No of reflec- tions	Guinier-Hägg Data at 24± 1°C	Literature Value in Å	Technique	Ref.					
	Cubic Symmetry									
α-Fe	3	$a_0 = 2.8659 \pm 4$	2.86615 ± 2	D-S+N-R(20 [°] C)	26					
ThO ₂	9	$a_0 = 5.5971 \pm 2$	5.5971 ± 1	Diffractometer (26 ⁰ C)	27					
			5.5969 ± 1	$D-S+N-R(25^{\circ}C)$	28					
Pb(NO ₃) ₂	19	a _o = 7.8552 <u>+</u> 1	7.8561 ± 6 (7.8555 ± 1*)	D -S +N - R(23 [°] C)	29					
Mo ₃ Sb ₇	23	a ₀ = 9.5688 ± 2	9.5688 ± 1	D-S+N-R (23 ⁰ C)	30					
		Tetragonal	Symmetry							
a-Sn	12	$a_0 = 5.8312 \pm 2$	5.8315 \pm 2	D-S+N-R(25 ⁰ C)	31					
·· ·		0 - 3.1808 - 2	3.1012 1 2		[
	T	Hexagonal	Symmetry	······································	r					
α -Al ₂ O ₂	20	$a_0 = 4.7587 \pm 2$	4.7591 ± 4	D-S+N-R (25 ⁰ C)	32					
2 3		$c_0 = 12.991 \pm 1$ a = 5.0351 + 1	5.0345 ± 5							
α-Fe ₂ O ₃	16	$c = 13.7515 \pm 5$	13.749 ± 2	D-S+N - R (20 ⁰ C)	33					
	22	$a_0 = 4.9125 \pm 1$	4.9125 ± 5	$D \in \mathbb{N}$ $D(10^{\circ} C)$	21					
α -Quartz (SiO ₂)	23	$c_0 = 5.4044 \pm 3$	5.4042 ± 5	D = 3 + N - K(10 C)	74					
		Orthorhombi	ic Symmetry							
		a ₀ = 3.3140 ± 2	3.3138 ± 2							
Black P	18	b _o = 10.479 ± 1	10.4776±6	D-S+N-R(22 ⁰ C)	35					
		$c_0 = 4.3769 \pm 4$	4.3759 ± 3							
Monoclinic Symmetry										
		$a_0 = 6.7218 \pm 2$	6.7215 ± 2	Single crystal						
$BaCl_2 - 2H_2O$	132	$b_0 = 10.9083 \pm 4$	10.9077±3	Diffractometer	36					
		$c = 7.1321 \pm 2$	7.1315 ± 3	Least squares refinement of						
		$\beta = 91.102^{-} \pm 3$	91.102 ± 3	12 sin ² 0 hkl						

= This work.

D-S =

Debye-Scherrer powder pattern. Nelson-Riley extrapolation for data correction. N-R =



Fig.1b Generation of a cone of reflection in powder diffraction.

-



Fig. 2b. Average number of powder lines per unit of Bragg angle and schematic appearance of powder pattern.



Fig.3 Percentage precision of d as a function of θ for various errors $\Delta \theta$



Fig.4 Intensity Distribution for CuK Radiation with superimposed Ni - Co Absorption Edges.



(a) Plane Parallel



(b) Tilted Surface





(a) Johann Bent Crystal

- $\frac{R}{2}$ = Radius of focal circle R Radius of crystal curv
- Radius of crystal curvature
- C Radius of caustic (error circle)



(b) Johannson Ground and Bent Crystal (Symmetrical)



Fig 7. Guinier camera geometries for diffraction from monochromator and from sample



Fig. 8 Alternative placings of asymmetric cassette for operation at angles up to 45°(0).



Fig. 9 Fully adjustable Crystal Monochromator for use with fine-focus sources

-





(1) incorrect distance source to crystal

(2,3,&4) correct source-crystal distance for focusing

Fig.11 Alignment of the Monochromator Crystat.


PLATES I & II

COMPARISON PHOTOGRAPHS OF POWDER PATTERNS

obtained with

- A. Debye Scherrer camera of $11 \cdot 46$ cm diameter (2 mm = $1^{\circ}\theta$) CuK $\alpha_{1, 2}$ radiation
- B. Guinier Hägg camera of 8 cm diameter (2 \cdot 8 mm = $1^{\circ}\theta$) CuK α_1 radiation





APPENDIX I

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LISTING OF COMPUTER PROGRAMME MOTT

DOS FORTRAN IV 360N-F0-479 3-1 DATE TIME MAINPGM 02/09/70 15.42.25 С С MOTT : A PROGRAMME FOR DERIVING BRAGG ANGLES FRUM FILM MEASURFMENTS BASED ON REFERENCE С GUINIER-HÄGG С С PROVIDED BY AN INTERNAL CALIBRANT. REFLECTIONS WRITTEN BY ALLAN BROWN, ATOMENERGI, STUDSVIK, 1966 С 00000 151 CARD : TITLE CARD ECRMAT (20A4) CARD : CONTROL CARD :NPUNCH, NREF, SO, LAMBDA, NEWCAL 2ND 0000 FORMAT(215,2F10,5,45X,15) NPUNCH=0 :DATA ARE PUNCHED ON CARDS IN FORM H,K,L,SINSQ(THETA),WI,IVL (315,2F10.5,12) :NO DATA CARDS PRUDUCED = 1 NREE **:**NO OF REFERENCE (CALIBRANT) REFLECTIONS 0000000000 USED READING OF POSITION OF PRIMARY BEAM SO TRACE ON FILM LAMBDA WAVELENGTH OF RADIATION USED (DATA FOR A SECOND SPECTRAL COMPONENT IS TREATED AS A SECOND PROBLEM NEWCAL=0 :ONLY ONF PROBLEM TO BE TREATED =1 :THIS DATA DECK TO BE FULLOWED BY A SECOND (NEW TITLE AND CONTROL CARDS) č С 3RD CARD : REFERENCE DISTANCES (REFX) FOR CALIBRANT REFLECTIONS С NREF VALUES (MAXIMUM OF 8) WITH FORMAT 8F10.0 0 0 0 FORMED BY SUBTRACTING BY HAND SO FROM READINGS OF POSITION OF REFERENCE REFLECTIONS 0 0 0 0 0 4TH CARD : RFFERENCE CAMERA CUNSTANTS (REFY) NREF VALUES CORRESPONDING TO REFX WITH SAME FORMAT FORMED BY DIVIDING BY HAND REFX VALUE BY BRAGG ANGLE FOR REFERENCE REFLECTION С C C DATA CARDS: H,K,L,S,WI,IVL FORMAT(315,2F1C.5,12) ANY NUMBER MILLER INDICES FOR MEASURED н С С REFLECTIONS : USED FUR IDENTIFICATION к NOT NECESSARY TO CALCULATION L READING OF POSITION OF REFLECTION С S с С (FROM SAME ORIGIN AS USED FOR PRIMARY BEAM) С С WEIGHTING FACTOR FOR RELIABILITY OF WI MEASUREMENT FOR PUNCHING ON DUTPUT 0 0 0 CARDS : CAN BE LEFT BLANK I VL INDICATOR FUR CHANGE OF WAVELENGTH FOR PUNCHING ON OUTPUT CARDS USED WITH с с MOTT-CELL LEAST SQUARES PROGRAMME CAN BE LEFT BLANK C C END CARD PUNCH 1 IN COLUMN 1 OF CARD FOLLOWING LAST С DATA CARD C C ¢

С С

nos	FURTRAN	١v	360	N-FQ-479	3-1	MAINPGM	DATE	02/09/70	TIME	15.42.25
000	1			DIMENSI	0% IH(3),	REFX(8),REFY(8),1	IIT(20)			
000	2			REAL LA	MBDA					
		С								
600	3		100	FORMAT(215,2F10.	5,45K,I5)				
600	4		101	FURMAT(8F10.0)					
000	5		102	FORMAT(315,2F1C.	5,12)				
000	6		103	FORMAT(5F10.5,2X	,315,17,5X,F10.51	l i i i i i i i i i i i i i i i i i i i			
000	7		104	FORMAT(101,5X,1S	5',7X,'S-SO',8X,'C	K • , 5 X , • 1 HET	A	Q°,7X,°H°	• 4
			1	×x, •K•,4	X,'L',6X,	"N',10X,'D',/)				
000	18		105	FORMAT(11,20X,	THIS MOTT CALCU	JLATION CON	ICERNS MEASI	JRED GUI	NI
			,	ER INT	ERVALS F	08',/)				
000	9		106	FORMAT('0',20A4,	/////>				
001	.C		107	FORMAT(2044)					
001	. 1		108	FORMAT(101, THE	FOLLOWING , 15,2>	., •CALIBRATI	NG POINTS	HAVE BE	EN
			3	* USED!	+///)					
001	.2		109	FORMAT('0',20X,'	S-SO(CAL) ',8F10.	31			
0r 1	.3		110	FORMAT('0',20X,'	CK(CAL) .8F	10.61			
001	.4		111	FORMAT(*G*,20X,*	SO = F10.320X	LAMBDA = ',	F10.5, 4,	//)	
		С								
001	.5		7	READ(5,	107)(TIT(I),I=1,20)				
C(1	6			RLAD(5,	100)NPUNC	H, NREF, SI, LAMBDA,	NEWCAL			
001	.7			READ(5,	101)(PEFX	(I),I=1,NREF)				
001	.8			READ(5,	101)(REFY	(I),I=1,NREF)				
001	.9			WRITE (6	,105)					
002	lu -			WRITE (6	,106)(TIT	(I),I=1,20)				
C 0 2	1			WRITE (6	,108)NREF					
002	2			WRITE (6	,109)(REF	X(I), $I=1$, NREF)				
662	3			WRITE (6	,110)(REF	Y(I), I=I, NREF)				
002	-			WRITE (6	,111)SU,L	AMBDA				
002	5			WRITE(6	,104)					
002	6			N=1						
002	(1		1	READ(5,	1021(10(1]+1≈1,3),5,WI+1VL				
002	6			111111)-1000012	1212				
001	· · ·		2	220=2-2						
00:				LALL IN	IIER (I, NRE	+ ,2,550,68,8857,				
003				THE TA=S	5076K	0.5305				
- Crig	2				HE IA/DI+2	(95795				
003	63			21NIH=2	INTIMKAUJ	· ·				
003	54 15			51:150=5						
003	5			1)=0.5*E	AMBUA/SIN	THE CH THETA STARD	(19/1) 1-1	21 N D		
0002	7			WKIIE(0	1117 2 2 1212922	UPURPTELAISINSU	117111111=11	JI + IN + U		
- UU3 - 7 5 5			7		じいりサラクナサー	T 1 1-1 21 CTNCO -	T TV1			
0.00	10		3	NK112(7	11351(1H)	1141-142142142644				
002	- C		4							
004	1		E	- 50 IU 1 - TEINEUC	AL 14.6.7		•			
604	7 L		 ∠		AL101011					
004	2		0	END						
UV4				CNU						

DOS	FORTRAN	I۷	367N-F0-479	3-1	INTER		DATE	02/09/70	TIME		15.44.10
000	01		SUBROUT	INE I	NTER(JB, JE, L, XP,	YP,X	,Y)				
000	22		DIMENSI	ON X	1),Y(1)						
000	53		100 FORMAT(51HO	TOO HIGH ORDER O	F IN	FERPOLATION	REQUESTED.	ORDER=,I	3,5	0003
			1H USED)								0004
000	.4		101 FORMAT(5H1)	=,1PE12.4,16H N	11 FOI	N INTERVAL)				0005
000	55		IF(L+JB	-JE) 2	,2,1						0006
000	06		1 L=JE-JB								0007
000	27		WRITE(6	,1001	L						000B
000	28		2 IF(X(JB)-XP)	4,9,3						J009
000	9.		3 WRITE(6	,1011	ХР						0010
00	10		GO TO 9								0011
000	11		4 IF(XP-X	(JE)]	16,11,5						0012
COO	12		5 WRITE(6	,1011	хР						0013
000	[3		GO TO 1	1							0014
000	14		16 I=JB+1								0015
00	15		6 IF(XP-X	(1))8	,8,7						0016
001	16		7 I=I+1								0017
000	17		GD TO 6								0018
000	18		A IB=I-L/	2							2019
60)	19		I S= I + { L	+1)/2							0020
002	20		IF(IB-J	B)9,1	2,10						0021
003	21		9 IB=JB	-							0022
602	22		IS=L+JB								6023
602	23		GO TO 1	2							C024
002	24		10 IF(JE-I	S)11,	12,12						002
002	25		11 I8=JE-L								0026
002	26		IS=JE								0027
002	27		12 YP=0.								0028
002	28		DU 15 I	= 18,1	S						0029
002	29		A=Y(I)								0030
0.03	30		DO 14 K	=13,1	S						0031
003	31		IF(I-K)	13,14	,13						0032
003	32		13 A=A*(XP	-x(K))/(X(I)-X(K))						0033
003	33		14 CONTINU	E							0034
003	34		15 YP=YP+A								0035
003	35		RETURN								J036
003	36		END								0037

APPENDIX II

RESULTS OBTAINED FROM MEASUREMENTS OF SOME GUINIER - HÄGG PATTERNS OBTAINED IN ROUTINE STUDIES

REF	INEME	ENT O	F C	CE 02	CUBI	C			
1	н	к	L	SINSQ(0)	SINS	G(C)	CBS-CALC	D OBS	
	WAVE	ELENG	TH =	1.54051					
	1	1	1	0.060771	0.060	0775	-0.000004	3.12453	
	2	ō	Ō	0.081006	0.08	1033	-0.000027	2.70630	
	2	2	C	0.162093	0.162	2066	0.000026	1.91317	
	3	1	1	0.222802	0.222	2841	-0.000039	1.63183	
	2	2	2	0.243123	0.24	3099	0.000024	1.56215	
	4	0	0	0.324104	0.324	4133	-0.000028	1.35298	
	3	3	1	0.384852	0.384	4907	-0.000056	1.24162	
	4	2	0	0.405249	0.405	5166	0.000083	1.20997	
4	4	2	2	0.486206	0.480	5199	0.000007	1.10465	
	NUME	BER	ĴF	REFLECTION	15 = 9				
	NUME	BER O	FRE	FLECTIONS	USED =	9 F	CR A GATE OF	0.00030	
				PARAMETER	S STAN	DARD	DEVIATIONS	LAST SH	IFTS
		A	Ξ	5.41169	3	0.00	0134	0.0000	00

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REFIN	EMENT	OF	TH D2	CUBIC		
н	к	L	SINSQ(O)	SINSQ(C)	OBS-CALC	D OBS
W	AVELEM	NGTH	= 1.54051			
1 2 3 2 4 3 4 4 8	1 0 2 1 2 0 3 2 2 UMBER	1 0 1 2 0 1 0 2 0F	0.056782 0.075752 0.151478 0.208330 0.227271 0.302915 0.359851 0.378844 0.454523 REFLECTIONS	0.056815 0.075753 0.151506 0.208320 0.227258 0.303011 0.359826 0.378764 0.454517 = 9	-0.000033 -0.000001 -0.000028 0.000010 0.000012 -0.000097 0.000025 0.000080 0.000066	3.23243 2.79858 1.97906 1.68756 1.61571 1.39950 1.28402 1.25142 1.14250
N	UMBER	OF R	EFLECTIONS US	SED = 9 FC STANDARD D	DR A GATE OF	0.00030 LAST SHIFTS

A = 5.597126 0.000173 0.000000

REF	REFINEMENT OF		U	02	С	U	BIC	•						
ł	н к	L		SINSQ(0)	S	511	ทรด) (C)	OB	S-CAI	-C	D OB	S
	WAVEL	ENGTH	#	1.54051										
	1 1 2 0 2 2 3 1 2 2 4 0 3 3 4 2 4 2 NUMBE	1 0 1 2 0 1 0 2 8 0 F	f	0.059465 0.079318 0.158567 0.218091 0.237939 0.317226 0.376660 0.396444 0.475762 REFLECTION	0 0 0 0 0 0 0 0 0 0 0 0		059 079 158 218 237 317 376 396 475 9	947: 929 959 906 89 719 966 948 978	3 8 5 8 3 0 3 8 5		00000 00002 00002 00004 00004 00004 00004 00004 00004)8 20 28 23 46 35 33 23	3.158 2.734 1.934 1.649 1.579 1.367 1.255 1.223 1.116	67 95 32 36 07 57 05 33 71
	NUMBE	R OF I	RE	FLECTIONS	USED) =	=	9	FOR	A (GATE	OF	0.00	030
				PARAMETER	rs s	iT/	AND	AR	D DE	VIA1	TIONS	5	LAST	SHIFTS
	1	4	Ξ	5.47059	95			0.0	0001	07			-0.0	00000

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REF	INEM	ENT O	F	PU 02	CUBIC		
	н	к	L	SINSQ(0)	SINSQ(C)	OBS-CALC	D CBS
	WAV	ELENG	тн	= 1.54051			
	1 2 3 2 4 3 4 4 4	1 2 1 2 0 3 2 2 8	1 0 1 2 0 1 0 2	0.061076 0.081603 0.163009 0.224112 0.244489 0.326093 0.387298 0.407643 0.489421 REFLECTION	0.061150 0.081533 0.163067 0.224217 0.244600 0.326134 0.387284 0.407667 0.489200 S = 9	-0.000074 0.000070 -0.000058 -0.000105 -0.000112 -0.000041 0.000015 -0.000024 0.000221	3.11672 2.69638 1.90778 1.62705 1.55778 1.34885 1.23769 1.20641 1.10101
	NUM	BER O	FR	EFLECTIONS PARAMETER	USED = 9 F S STANDARD	OR A GATE OF	0.00030 LAST SHIFTS
		A		= 5.39506	6 0 . 00	0357	0.000000

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REFINEMENT OF							
			PB(N03)2	CUBIC			
H	I K	L	SINSQ(D)	SINSQ(C)	OBS-CALC	D OBS	
	WAVELE	NGIH	= 1.54051				
1	1	1	0-028876	0.028845	0.00031	4.53281	
2	Ō	ō	0.038455	0.038460	-0.000005	3.92787	
2	, i	ŏ	0.048090	0.048076	0.000014	3.51243	
2	, ,	1	0.057729	0.057691	0.000039	3.20580	
2	2	ō	0.076935	0.076921	0.000014	2.77698	
3	1	ĩ	0.105782	0.105766	0.000016	2.36826	
2	2	2	0.115395	0.115381	0.000014	2.26747	
4		ō	0.153857	0.153842	0.000015	1.96370	
3	ž	ĭ	0.182708	0.182687	0.000021	1.80200	
4	2	ō	0.192310	0.192302	0.000007	1.75644	
. 4	2	2	0.230772	0.230763	0.000009	1.60340	
5	1	ī	0.259544	0.259608	-0.000063	1.51192	
4	4	ō	0.307661	0.307683	-0.000022	1.38867	
5	3	ĩ	0.336595	0.336529	0.000066	1.32764	
6	, Ö	0	0.346090	0.346144	-0.000054	1,30930	
6	2	ŏ	0.384565	0.384604	-0.000039	1.24208	
5	3	3	0.413534	0.413450	0.000084	1,19779	
6	2	2	0.423049	0.423065	-0.000016	1.18424	
7	1	ī	0.490281	0.490371	-0.000089	1.10005	
6	4	ō	0.500051	0.499986	0.000065	1.08925	
	·	-					
	NUMBER	0 F	REFLECTIONS	= 20			
		05 0	SELECTIONS U			0 00020	
	NUMDEK	UFR	CLECITONS 0	3EV = 20 FL	IK A GALE UP	0.00050	
			PARAMETERS	STANDARD D	DEVIATIONS	LAST SHIFTS	

A = 7.855203 0.000138 0.000000

REFI	INEMENT	0 F	M03 SB7	CUBIC		
ł	Η K	L	SINSQ(D)	SINSQ(C)	OBS-CALC	D CBS
	WAVELE	NGTH	= 1,54051			
i	2 0	0	0.025921	0.025918	0.000002	4.78422
2	21	1	0.038885	0.038877	0.00008	3.90608
3	3 1	0	0.064801	0.064796	0.000005	3.02583
	22	2	0.077771	0.077755	0.000017	2.76201
3	3 2	1	0.090701	0.090714	-0.000013	2.55758
4	4 0	0	0.103679	0.103673	0.000006	2.39216
4	4 1	1	0.116614	0.116632	-0.000018	2.25558
4	4 2	0	0.129575	0.129591	-0.000017	2.13981
4	4 4	Û	0.207313	0.207346	-0.000033	1.69169
-	5 3	0	0.220313	0.220305	0.00008	1.64102
4	4 4	2	0.233277	0.233264	0.000013	1.59477
	5 3	2	0.246228	0.246223	0.000005	1.55226
e	52	Û	0.259196	0.259182	0.000013	1.51294
-	5 4	1	0.272156	0.272142	0.000015	1.47647
6	5 2	2	0.285089	0.285101	-0.000012	1.44259
7	72	1	0.349919	0.349896	0.000023	1.30212
-	7 3	0	0.375814	0.375815	-0.000001	1.25646
6	5 5	1	0.401699	0.401733	-0.000034	1.21530
8	30	0	0.414719	0.414692	0.000027	1.19607
8	B 1	1	0.427612	0.427651	-0.000039	1.17790
	5 4	4	0.440616	0.440610	0.000006	1.16039
8	82	2	0.466549	0.466528	0.000020	1.12768
e	5 6	2	0•492445	0.492447	-0.000002	1.09763
	NUMBER	0F	REFLECTIONS	= 23		
	NUMBER	OF R	EFLECTIONS U	SED = 23 F	OR A GATE OF	0.00020
			PARAMETERS	STANDARD	DEVIATIONS	LAST SHIFTS
	А		= 9.568894	Ð.00	0071	0.000000

T.1.41		Ur	SI 02	{ALPHA	QUARTZ)	HEXAGONAL	
н	к	L	SIN	SQ(O)	SINSQ (C) OBS-CAL	C D OBS
W	AVELE	NGTH	= 1.	54051			
1 1 1 1 1 2 1 2 1 2 1 2 2 3 1 3 2	0 0 1 0 1 0 0 1 0 0 1 1 0 0 0 0 0 0 0	0 1 0 2 1 0 1 2 2 3 1 3 2 3 1 4 2 3	0.03 0.09 0.11 0.11 0.12 0.12 0.12 0.12 0.22 0.24 0.22 0.24 0.22 0.24 0.23 0.31 0.31 0.33 0.33 0.33	32804 53210 98312 13985 18654 31164 51362 79485 12307 15630 49655 31149 10691 13929 15319 57735 76249	0.0327 0.0530 0.0983 0.1140 0.1186 0.1311 0.1514 0.1795 0.2123 0.2155 0.2497 0.2811 0.3107 0.3139 0.3153 0.3577 0.3762	79 0.00002 92 0.00011 37 -0.00002 29 -0.00004 50 0.00004 29 -0.00004 29 -0.00004 29 -0.00006 38 -0.00010 57 -0.00006 93 0.00003 56 -0.00001 51 -0.00000 30 -0.00000 31 -0.00004 52 -0.00001	5 4.25279 8 3.33916 5 2.45658 5 2.28145 5 2.23611 7 2.12681 7 2.12681 7 1.97982 2 1.81811 0 1.67168 7 1.65875 1 1.54157 2 1.38188 1 1.37473 5 1.37170 6 1.28782 3 1.25573
2 2 1 3 3	2 1 2 1 1 1	0 3 1 4 0 1	0.39 0.41 0.41 0.42 0.42	93361 12323 13612 23394 26168 46515	0.39334 0.41226 0.41366 0.42332 0.42612 0.44644	48 0.00001 57 0.00005 51 -0.00004 39 0.00005 27 0.00004 40 0.00007	3 1.22811 6 1.19954 9 1.19767 6 1.18375 1 1.17990 5 1.15270
NL	JMBER	0 F	REFLE	ECTIONS	= 23		
N	JMBER	OF F	REFLECT	TIONS U	SED = 23	B FOR A GATE	OF 0.00020
	A C		PARA = 4. = 5.	METERS 912537 404452	STANDAF 04 04	RD DEVIATIONS 000143 000270	LAST SHIFTS 0.000000 0.000000

REFINEMENT OF

REFI	NEMENT	OF	AL2 G3	HEXAGONAL		
۲	ĸ	L	SINSQ(O)	SINSQ(C)	OBS-CALC	D OBS
	WAVELEN	NGTH	= 1.54051			
1	. 0	2	0.048930	0.048995	-0.000065	3.48215
1	0	4	0.091080	0.091183	-0.000103	2.55225
1	. 1	0	0.104760	0.104796	-0.000036	2.37978
1	. 1	3	0.136400	0.136437	-0.000037	2.08558
2	0	2	0.153670	0.153790	-0.000120	1.96490
2	0	4	0.195890	0.195979	-0.000089	1.74032
1	. 1	6	0.231270	0.231361	-0.000091	1.60168
2	2 1	2	0.258540	0.258586	-0.000046	1.51485
1	0	8	0.259910	0.259938	-0.00028	1.51086
2	1	4	0.300780	0.300775	0.000005	1.40446
3	0	0	0.314260	0.314387	-0.000127	1.37401
2	0	8	0.364830	0.364733	0.000097	1.27523
1	0	10	0.386500	0.386503	-0.000004	1.23897
1	1	9	0.389540	0.389569	-0.000029	1.23412
2	2	0	0.419230	0.419182	0.000047	1.18962
3	0	6	0.441080	0.440953	0.000127	1.15978
2	2	3	0.450830	0.450824	0.00006	1.14717
3	1	2	0.468220	0.468177	0.000043	1.12567
2	2 1	8	0.469590	0.469529	0.000061	1.12402
2	0	10	0.491270	0.491299	-0.000029	1.09894
	NUMBER	OF	REFLECTIONS	5 = 20		
	NUMBER	OF R	REFLECTIONS 1	ISED = 20 EC	DR A GATE OF	0.00025
		0				•••••
			PARAMETERS	S STANDARD E	DEVIATIONS	LAST SHIFTS
	Δ		= 4.758751	0.000	0189	0.00000
			= 12,990552	0.000	0735	0.000000
	•					

REFI	NEMENT	OF				
			ALPHA-FE2 03	HEXAGCNAL		
F	і К	L	SINSQ(O)	SINSQ(C)	OBS-CALC	D OBS
		NGTH	= 1.54051			
		10 111	1004001			
		_			<i>.</i>	
1	. 0	2	0.043722	0.043753	-0.000031	3.68371
1	. 0	4	0.081464	0.081402	0.000062	2.69868
1	. 1	0	0.093655	0.093610	0.000045	2.51692
]	1	3	0.121902	0.121847	0.000056	2.20612
2	2 0	4	0.175000	0.175012	-0.000012	1.84126
]	. 1	6	0.206586	0.206558	0.000029	1.69466
1	. 0	8	0.232033	0.232000	0.000033	1.59904
2	1	4	0.268601	0.268622	-0.000020	1.48621
3	6 0	0	0.280789	0.280829	-0.000040	1.45360
1	. 0	10	0.344893	0.344948	-0.000054	1.31157
2	2	0	0.374420	0.374439	-0.000019	1.25880
3	0	6	0.393812	0.393777	0.000035	1.22741
2	2 1	8	0.419208	0.419219	-0.000011	1.18965
2	2 Ō	10	0.438541	0.438557	-0.000016	1.16313
3	· 1	-4	0.455842	0.455841	0.000001	1.14085
2	2	6	0.487372	0.487387	-0.000014	1.10333
_		-				
	NUMBER	OF	REFLECTIONS	= 16		
	NUMBER	OF F	REFLECTIONS U	SED = 16 FO	R A GATE OF	0.00050
			PARAMETERS	STANDARD D	EVIATIONS	LASI SHIFTS
	Δ		= 5.035054	0.000	168	0.000000
	Ĉ		= 13.751387	0,000	696	0.000000
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REFI	NEMENT	UF					
			CA5(OH)(PO4)3	HEXAGONAL	HYDROXY	APETITE	,
ы	×	ı	STNSO(O)	SINCOLO	085-0410		
п	N	L	21426101	211120101	UBS-CALC	D CR2	
1	WAVELE	NGTH	= 1.54051				
_	_						
1	0	C .	0.008890	0.008917	-0.000027	8.16928	
1	0	1	0.021360	C+021440	-0.000080	5.27028	
2	1	1	0.039340	0.030274	-0.000127	4.08579	
	0	2	0.050020	0.050092	-0.000074	3.44400	
1	č	2	0.058880	0.059009	-0.000129	3,17432	
2	1	ō	0.062360	0.062418	-0.000058	3.08448	
2	ī	1	0.074890	0.074941	-0.000051	2.81464	
1	1	2	0.076840	0.076843	-0.000003	2.77869	
3	0	0	0.080190	0.080252	-0.000062	2.72003	
2	0	2	0.085730	0.085760	-0.000030	2.63068	
3	0	1	0.092840	0.092775	0.000065	2.52794	
2	1	2	0.112520	0.112510	0.000010	2.29625	
3	1	0	0.115970	0.115919	0.00051	2.26184	
2	2	1	0.129240	0.129662	-0.000185	2.14015	
1	1	2	0.139470	0.139458		2 04250	
2	2	2	0.157090	0.157094		1.94339	
3	1	2	0.166050	0.166011	0.000039	1.89023	
3	2	ō	0.169300	0.169420	-0.000120	1.87200	
2	1	3	C.175170	C.175125	0.000045	1.84037	
3	2	1	0.181970	C•181943	0.000027	1.80565	
4	1	0	0.187380	0.187254	0.000126	1.77940	
4	0	2	0.192790	0.192762	0.000028	1.75425	
0	0	4	0.200400	0.200369	0.000031	1.72062	
2	2	2	0.228580	0 228626	-0.000032	1 61107	
4	2	с о	0.249740	0.249672	0,000048	1.54131	
3	3	ĩ	0.253420	0.253278	0.000142	1.53008	
2	1	4	0.262640	0.262786	-0.000146	1.50298	
5	0	2	0.273070	0.273013	0.000057	1.47400	
3	0	4	0.280600	0.280620	-0.000020	1.45409	
5	1	1	0.288930	0.288945	-0.000015	1.43297	
4	2	2	0.299780	0.299764	0.000016	1.40680	
5 /	1	2	0.343580	0.320514	-0.000164	1.34832	
	2	1	0.347970	0 347757	0.000134	1.31399	
5	2	ĭ	C.36030C	0.360280	0.000215	1.28322	
4	2	3	0.362270	0.362379	-0.000109	1.27973	
2	1	5	0.375480	0.375494	-0.000014	1.25702	
4	3	2	0.380010	0.380015	-0.000005	1.24950	
6	1	Ú	0.383220	C•383424	-0.000204	1.24426	
4	1	4	0.387820	0.387622	0.000198	1.23686	
5	1	3	0.388980	0.389129	-0.000149	1.23501	
2 6	2	2	0.420050	0.391849	0.000131	1.22097	
4	-+ 2	2	0.442650	0.442630	0.000042	1.15772	
4	2	4	0.449970	6.450040	-0.000070	1.14827	
1	1	6	0.477730	0.477580	0.000150	1.11441	
3	2	5	0.482600	0.482496	0.000104	1.10877	

NUMBER OF REFLECTIONS = 50

NUMBER	OF	REFL	ECTIONS US	ED = 50 FOR A GATE OF	0.00030
		F	ARAMETERS	STANDARD DEVIATIONS	LAST SHIFTS
А		=	9.418860	0.000456	0.000000
C		=	6.883031	0.000556	0.000000

REFI	NEMENT	OF	TH AU3	HE XAGONAL	P6(3)	
н	I K	Ł	SINSQ(D)	SINSQ(C)	OBS-CALC	D OBS
		_				
	WAVELE	NGTH	= 1.54051			
0	0	2	0.027890	0.027858	0.000032	4.61222
2		2	0.061610	0.061570	0.000040	3.10319
2	2	1	0.064830	0.064755	0.000075	3.02515
3	1	1	0.069510	0.069571	-0.000061	2.92153
3	0	2	0.071170	0.071201	-0.000031	2.88726
1	1	3	0.077120	0.077129	-0.000009	2.77365
4	0	1	0.084040	C.084019	0.000021	2.65700
2	2	2	0.090450	0.000465	-0.000031	2.56112
3	2	0	0.091530	0.091502	0.000028	2.54597
2	1	3	0.096330	0.096393	-0.000063	2.48173
3	2	1	0.098620	0.098466	0.000154	2.45274
4	1	0	0.101170	0.101133	0.000037	2.42163
3	0	3	0.105880	0.106024	-0.000144	2.36716
4	· · ·		0.111300	0.108098		2.34208
1	0 0	4	0.116220	0.116249	-0.000044	2.25941
3	2	2	0.119280	0.119360	-0.000080	2.23024
5	0	G	0.120410	0.120397	0.000013	2.21975
3	1	3	0.125240	0.125288	-0.000048	2.17652
4	1	2	0.129070	0.128992	0.000078	2.14399
2	0	4	0.130560	0.130697	-0.000037	2.13090
4	2	1	0.141780	0.141809	-0.000009	2.04563
2	1	4	0.145230	0.145145	0.000085	2.02119
5	1	Ü	0.149300	0.149292	0.00008	1.99345
3	2	3	0.154130	0.154183	-0.000053	1.96196
4	2	2	0.162640	0.162703	-0.000063	1.90994
4		3	0.163650	0.163815	-0.000165	1.90404
23	1	4	0.173970	0.174040	-0.000004	1.84670
4	3	ò	0.178150	0.178188	-0.000038	1.82491
6	0	1	0.180200	0.180336	-0.000136	1.81450
1	1	5	0.188560	0.188563	-0.000003	1.77382
5	2	1	0.194990	0.194784	0.000206	1.74433
4	2	5	0.197410	0.19/520	-0.000116	1.70936
2	2	5	0.207630	0.207826	-0.000196	1.69040
4	1	4	0.212360	0.212567	-0.000207	1.67147
6	1	2	0.234790	0.234941	-0.000151	1.58963
3	1	5	0.236640	0.236721	-0.00081	1.58340
4	3	3	0.240840	0.240869	-0.000029	1.56953
4 F	2	4	0.246190	U.246278	-0.000088	1.55238
2 5	1	ر د	0-260830	0.260726	0.000104	1.50819
7	Ō	2	0.263910	0.263837	0.000073	1.49936
6	1	3	0.269700	0.269764	-0.000064	1.48318
4	1	5	0.275090	0.275248	-0.000159	1.46858
6	2	2	0.278320	0.278284	0.000036	1.46003
6	0	4	0.284660	0.284805	-0.000145	1.44368
- 4	3	4	U.289630	U.289621	0.000009	1.43124

5	4	0	0.293770	0.293769	0.000001	1.42112
5	2	4	0.299130	0.299253	-0.000123	1.40833
6	3	0	0.303430	0.303400	0.000030	1.39832
2	2	6	0.308490	0.308516	-0.000026	1.38680
6	3	1	0.310330	0.310365	-0.000035	1.38268
6	2	3	0.313170	0.313107	0.000063	1.37640
8	0	1	0.315430	0.315181	0.000249	1.37146
6	1	4	0.318570	0.318516	C.000054	1.36468
4	0	6	0.327690	0.327780	-0.000090	1.34556
7	1	3	0.337120	0.337187	-0.000067	1.32661
6	0	5	0.347490	0.347487	0.000003	1.30666
4	1	6	0.351840	0.351859	-0.000019	1.29856
5	0	6	0.371170	0.371123	0.000047	1.26429
3	3	6	0.380850	0.380754	0.000096	1.24812
5	1	6	0.400270	0.400018	0.000252	1.21747
8	2	U	0.404310	0.404534	-0.000224	1.21137
4	4	5	0.405290	0.405277	0.000013	1.20991
7	3	2	0.408360	0.408313	U.000047	1.20535
6	3	4	0.414740	0.414834	-0.000094	1.19604
6	2	5	0.424590	0.424541	0.000049	1.18209
4	3	6	0.429210	0.428913	0.000297	1.17571
3	2	7	0.432980	0.432767	0.000213	1.17058
9	1	6	0.438230	0.438245	-0.000015	1.16355
4	1	7	0.442500	0.442399	0.000101	1.15792
0	0	8	0.445720	0.445734	-0.000014	1.15373
9	0	3	0.453090	0.452768	0.000322*	1.14431
6	1	6	0.457800	0.457808	-0.000009	1.13840

NUMBER OF REFLECTIONS = 79

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 NUMBER OF REFLECTIONS USED =
 78 FOR A GATE OF
 0.00030

 PARAMETERS
 STANDARD DEVIATIONS
 LAST SHIFTS

 A
 =
 12.81640C
 0.000535
 0.000000

 C
 =
 9.229675
 0.000499
 0.000000

REFINEMENT		OF	ALPHA-TIN	TETRAGONAL				
н	к	L	SINSQ(0)	SINSQ(C)	OBS-CALC	D OBS		
	WAVELE	NGTH	= 1.54051					
2 1 2 3 1 4 3 4	0 2 1 0 1 0 2 2	0 1 1 2 0 1 0	0.069770 0.076097 0.139628 0.145950 0.215641 0.269478 0.279197 0.285417 0.348982	0.069792 0.076090 0.139585 0.145883 0.215675 0.269464 0.279170 0.285468 0.348962	-0.000023 0.000007 0.000043 0.000067 -0.000034 0.000014 0.000027 -0.000050 0.000020	2.91609 2.79222 2.06134 2.01620 1.65870 1.48379 1.45774 1.44176 1.30387		
4 3 4	1 3	1 2 1	0.409038	0.409049	-0.000011 -0.000040	1.29225 1.20435 1.09501		
I	NUMBER	OF	REFLECTIONS	= 12				
ł	NUMBER	OF R	EFLECTIONS US	SED = 12 FC	DR A GATE OF	0.00020		
			PARAMETERS	STANDARD D	DEVIATIONS	LAST SHIFTS		

4

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Α	=	5.831230	0.000159	0.00000
С	=	3.180755	0.000189	0.000000

REF	INEM	ENT	0 F				
				MN3 04	TETRAGONA	L	
						-	
	н	κ	L	SINSQ(D)	SINSQ(C)	OBS-CALC	D OBS
	WAVI	ELEN	IGTH	= 1.54051			
	•	~	•	0 024427	0 024512	0 00007/	(00705
	1	1	1	0.0499497	0.04315		4.92133
	1	1	2	0.071502	0.071571	-0.000024	2.00/40
	2	0	2	0.077626	0.077474		2.00000
	1	ů,	3	0.006112	0.00/09/	-0.000037	2.10191
	2	L	1	0.090112	0.096084	0.000028	2.48424
	2	0	2	0.097997	0.098052	-0.000055	2.46053
	0	0	4	0.105968	0.105922	0.000046	2.36518
	2	2	Ŭ,	0.143082	0.143142	-0.000060	2.03630
	2	0	4	0.177480	0.177493	-0.000013	1.82835
	1	0	5	0.183374	0.183395	-0.000021	1.79873
	3	1	2	0.205314	0.205408	-0.000095	1.69991
	3	2	1	0.239156	0.239226	-0.000071	1.57505
	2	2	4	0.248965	0.249064	-0.000099	1.54371
	4	0	0	0.286355	0•286284	0.000071	1.43940
	3	0	5	0.326620	0.326538	0.000082	1.34776
	4	1	3	0.363825	0.363758	0.000067	1.27699
	4	2	2	0.384365	0.384336	0.00029	1.24240
	4	0	4	0.392214	0.392206	0.00008	1.22991
	2	1	7	0.413831	0.413849	-0.000018	1.19735
	3	1	6	0.417277	0.417252	0.000026	1.19240
	4	1	5	0.469670	0.469680	-0.00010	1.12393
				,			
	NUMI	BER	OF	REFLECTIONS	= 21		
	NUMI	BER	UF R	EFLECTIONS US	5ED = 21 FC	UR A GATE OF	0.00020
				DADANETEDS	STANDADD I		IACT CUTETC
				FARAMETERS	STANDARU I	DEATUITONS	FASI SUILIS
		۵	:	= 5,758319	0.000	1237	-0.000000
		ĉ	:	= 9.466774	0.000	0595	-0.000000

•

REFIN	EMENT	OF				
			SR(DH)2.8H2	O TETRAGONA	L P4/NCC	
н	к	L	SINSQ(D)	SINSQ(C)	OBS-CALC	D DBS
ш		матн	± 1.54051			
	A1666	10111	- 1.54051			
-	_					
1	1	2	0.017587	0.014597	-0.000037	6 • 38 348 5 • 80820
2	ŏ	ō	0.029177	0.029193	-0.000016	4.50933
1	1	2	0.032192	0.032209	-0.000018	4.29301
2	0	2	0.046824	0.046806	0.000018	3.55958
0	ő	4	0.070506	0.070451	0.000020	2.90082
2	2	2	0.076037	0.075999	0.000038	2.79334
3	1	1	0.077366	0.077386	-0.000020	2.76924
1	1	4	0.085036	0.085048	-0.000012	2.64139
2	0	4	0.099700	0.099644	0.000055	2.43942
2	i	4	0.106993	0.106943	0.000050	2.35481
3	1	3	0.112650	0.112612	0.000039	2.29492
4	0	0	0.116866	0.116772	0.000093	2.25316
3	3	ō	0.131380	0.131369	0.000011	2.12505
4	ō	2	0.134428	0.134385	0.000043	2.10082
3	1	4	0.143486	0.143434	0.000052	2.03343
4	2	2	0.140031	0.145965	0.000066	2.01064
4	2	ī	0.150416	0.150368	0.000048	1.98603
0	0	6	0.158616	0.158516	0.000100	1.93402
4	2	2	0.163607	0.163578	0.000029	1.90429
1	1	5	0.183015	0.183063	-0.000051	1.80049
4	3	í	0.186980	0.186860	0.000120	1.78130
4	0	4	0.187223	0.187224	-0.000001	1.78015
2	0	6	0.187660	0.187709	-0.000049	1.76823
3	3	4	0.201862	0.201820	0.000042	1.71438
5	1	2	0.207390	0.207368	0.000023	1.69138
2	2	6	0.216812	0.216902	-0.000090	1.65422
5	1 3	0	0.231479	0.231498	-0.000019	1.54656
4	4	2	0.251126	0.251157	-0.000031	1.53705
5	3	1	0.252480	0.252544	-0.000063	1.53292
4 5	2	5	0.256013	0.256046	-0.000032	1.52231
5	3	2	0.265713	0.265754	-0.000041	1.49427
4	Ō	6	0.275193	0.275288	-0.000095	1.46830
6	0	2	0.280280	0.280350	-0.000070	1.45492
3	1	87	0.281651	0.281806	-0.000045	1.43376
3	3	6	0,289916	0.289884	0.000031	1.43054
6	2	0	0.291843	0.291930	-0.000087	1.42580
6	2	1	0.296222	0.296334	-0.000112	1.41523
4	2	6	0.304404	0.304481	-0.000077	1.39608
6	2	2	0.309471	0.309543	-0.000073	1.38460
5	3	4	0.318508	0.318592	-0.000084	1.36482
5	1	6	0.348223	0.348270	-0.000047	1.30529
3	1	8	0.354840	0.354788	0.000052	1.29306
6	2	4	0.362385	0.362382	0.000003	1.27953
0 4	4	6	0.392093	0.392060	0.000033	1.23010
6	4	2	0.397158	0.397122	0.000036	1.22223
6	3	4	0.398931	0.398873	0.000058	1.21951
5 2	3	6 8	0.413217	0.406657	0.000052	1.10924
6	õ	6	0.421283	0.421253	0.000030	1.18672
7	3	0	0.423318	0.423299	0.000019	1.18386
4	2	8	0.427763	0.427771	-0.000008	1.17769
7	3	2	0.440946	0.440912	0.000034	1.15996
6	2	6	0.450317	0.450446	-0.000129	1.14782
1	1	10	0.454916	0.454918	-0.000002	1.14201
2	1	8	0.471003	0.4/1961	0.000042	1+12162
NU	UMBER	OF	REFLECTIONS	= 69		
NI	UMBER	OF R	EFLECTIONS U	SED = 69 FOR	A GATE OF	0.00020
			PARAMETERS	STANDARD DE	EVIATIONS	LAST SHIFTS
	A		= 9.016229	0.0002	215	0.000000
	C		= 11.607788	0.0004	426	-0.000000

REFINE	MENT	0 F				
			SR (OH) 2. H20	ORTHOROMBIC	C PMMA	
н	ĸ	1	SINSO(D)	SINSO(C)		D OBS
.,		-	511154(0)	311134107	000 0420	0 000
WA	VELEN	IGTH	= 1.54051			
0	0	1	0.015390	0.015438	-0.000048	6.20891
1	0	1	0.028570	0.028597	-0.000027	4.55700
2	0	0	0.052640	0.052635	-0.000017	3.35719
ō	ĭ	ĭ	0.060030	0.060015	0.000015	3.14377
2	0	1	0.068110	0.068073	0.000037	2.95141
1	1	1	0.073190	0.073174	0.000016	2.84714
1	0	2	0.074920	0.074911	0.00009	2.81407
2	1	2	0.106330	0.106329	-0.000032	2.36215
2	1	ĩ	0.112680	0.112650	0.000030	2.29462
ī	ī	2	G.119500	0.119488	0.000012	2.22818
3	0	1	0.133930	0.133867	0.000062	2.10473
0 N	0	3	0.138980	0.138943	0.000037	2.06613
1	2	د 0	0.178290	0.178306	-0.000032	1+97521
3	ō	2	0.180110	0.180182	-0.000072	1.81495
Ō	ĩ	3	0.183470	0.183520	-0.000050	1.79826
2	0	3	0.191500	0.191578	-0.000078	1.76015
0	2	1	0.193760	0.193745	0.000015	1.74986
1	1	3	0.196680	0.196678	0.000002	1.60367
4	ō	ō	0.210530	0.210541	-0.000011	1.67872
3	1	2	0.224770	0.224758	0.000012	1.62467
4	0	1	0.226020	0.225979	0.000041	1.62017
2	2	0 2	0.230940	0.230942	-0.000002	1.60282
2	2	2 1	0.246290	0.246380	-0.000005	1.55207
õ	ō	4	0.246990	0.247010	-0.000020	1.54987
1	2	2	0.253250	0.253218	0.000032	1.53059
4	1	0	0.255040	0.255118	-0.000078	1.52521
3	0	3	0.25/320	0.257372	-0.000052	1.51844
4	1	4	0.291580	0.291586	-0.000046	1.48090
2	ō	4	0.299600	0.299645	-0.000045	1.40722
3	1	3	0.301890	0.301949	-0.000059	1.40188
3	2	1	0.312130	0.312174	-0.000044	1.37869
0	2	3	0.317230	0.317249	-0.000019	1.36756
5	õ	1	0.344430	0.344409	0.000021	1.31245
4	ŏ	3	0.349480	0.349484	-0.000004	1.30294
3	2	2	0.358430	0.358488	-0.000058	1.28657
2	2	3	0.369970	0.369885	0.000085	1.26634
5	0	2	0.390870	0.390723	-0.000003	1-23202
4	ĭ	3	0.394100	0.394061	0.000039	1.22696
1	0	5	0.398980	0.399112	-0.000132	1.21944
0	3	0	0.401120	0.401189	-0.000069	1.21618
4	2	1	0.404240	0.404286	-0.000046	1.21148
ŏ	2	4	0.425380	0.425316	0.000064	1.18099
ĩ	3	1	0.429830	0.429786	0.000044	1.17486
3	2	3	0.435570	0.435679	-0.000109	1.16709
2	o,	5	0.438670	0.438588	0.000082	1.16296
1	2	2	0.453790	0.453825	-0.000182	1.14342
4	õ	4	0.457510	0.457551	-0.000041	1.13877
2	3	1	0.469320	0.469263	0.000057	1.12435
6	0	0	0.473740	0.473718	0.000022	1.11909
1	3	2	0.476230	0.476101	0.000129	1.11616
6	2	4	0.489180	0.489156	0.000148	1.10129
4	ĭ	4	0.502070	0.502128	-0.000058	1.08706
NU	MBER	0F	REFLECTIONS	= 63		
NU	MBER	OFR	EFLECTIONS US	ED = 63 FOF	R A GATE OF	0.00030
			PARAMETERS	STANDARD DE	VIATIONS	LAST SHIF
	A		= 6.714691	0.0002	212	0.000000
	B		= 3.648220	0.0001	109	0.00000
	C		= 0.199225	0.0002	207	0.000000

SHIFTS

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REFINEMENT	OF	SR (OH) 2	ORTHOROMBIC	ΡΝΜΑ	
нк	L	SINSQ(O)	SINSQ(C)	OBS-CALC	D OBS
WAVELE	NGTH	= 1.54051			
WAVELE 1 0 0 2 0 0 1 1 0 2 0 0 2 1 0 1 0 0 2 0 0 2 1 0 1 0 0 2 0 0 2 1 0 1 0 0 2 0 0 1 2 0 0 2 2 0 2 2 0 2 2 0 0 2 0 0 2 1 1 0 1 2 0 1 1 0 0 0 0 0 2 2 0 2 3 2 2 0 2 3 2 1 2 0 0 0 0 0 2 2 0 2 3 2 1 2 0 0 0 0 0 0 0 0 0 0 0 0 0 0 0	NGTH 1011022112021220310231033123120213204411324314344321200433514444204225051214	= 1.54051 0.021910 0.024240 0.040100 0.054470 0.063370 0.069410 0.070490 0.078750 0.087680 0.097110 0.12970 0.112970 0.112970 0.112970 0.1126280 0.135720 0.151600 0.154510 0.156720 0.156720 0.166980 0.176460 0.176460 0.178840 0.181370 0.187500 0.206290 0.206290 0.206290 0.224950 0.224950 0.224950 0.224950 0.224950 0.224950 0.224950 0.2253560 0.253560 0.259800 0.267620 0.253560 0.259800 0.267620 0.253560 0.259800 0.267620 0.253560 0.259800 0.267620 0.278520 0.281860 0.332850 0.303440 0.313130 0.316580 0.350670 0.369550 0.369550 0.371770 0.352850 0.36950 0.40210 0.44510 0.442530 0.435310 0.436110 0.446810 0.4450950 0.46620 0.46620 0.467710 0.472120	0.021920 - 0.024268 - 0.06121 - 0.054489 - 0.063413 - 0.069480 - 0.070456 - 0.070456 - 0.078757 - 0.087681 - 0.097071 - 0.135707 - 0.135707 - 0.135707 - 0.154544 - 0.151560 - 0.154544 - 0.156652 - 0.166948 - 0.176465 - 0.178812 - 0.166948 - 0.176465 - 0.178812 - 0.166948 - 0.176465 - 0.25584 - 0.205584 - 0.205584 - 0.205584 - 0.205584 - 0.225000 - 0.225000 - 0.239751 - 0.253653 - 0.253653 - 0.253653 - 0.253720 - 0.267469 - 0.251615 - 0.253653 - 0.253720 - 0.267469 - 0.272899 - 0.267469 - 0.253653 - 0.253720 - 0.267469 - 0.332989 - 0.369631 - 0.402400 - 0.	0.000010 0.000028 0.000014 0.000014 0.000014 0.000034 0.000070 0.000034 0.000034 0.000034 0.000037 0.000034 0.000037 0.000037 0.000032 0.000035 0.000032 0.000035 0.000035 0.000035 0.000035 0.00005 0.00005 0.00005 0.00005 0.00005 0.00005 0.00005 0.00005 0.00005 0.00005 0.00005 0.00005 0.00005 0.00005 0.00005 0.00005 0.000037 0.000015 0.000015 0.000015 0.000015 0.000015 0.000013 0.000013 0.000015 0.000015 0.000015 0.000015 0.000015 0.000015 0.000015 0.000015 0.000015 0.000015 0.000017 0.000017 0.000017 0.000017 0.000017 0.000017 0.000017 0.000017 0.000005 0.00005 0.00005 0.00005 0.0000000 0.00005 0.00005 0.00000000	5.20372 4.94730 3.84647 3.30032 3.07145 3.05980 2.92364 2.90115 2.74479 2.60126 2.47174 2.34284 2.29167 2.24144 2.16754 2.99080 1.99773 1.97827 1.95955 1.94568 1.88496 1.83363 1.82139 1.80864 1.77883 1.745455 1.72606 1.69835 1.69588 1.66052 1.64782 1.62402 1.57277 1.56515 1.53524 1.56515 1.53524 1.52966 1.51118 1.48893 1.47427 1.45951 1.3509 1.37649 1.37649 1.33509 1.30779 1.30072 1.29854 1.228249 1.27754 1.26124 1.26327 1.26327 1.26458 1.21438 1.21438 1.21438 1.21438 1.2107 1.20572 1.19660 1.19255 1.17884 1.17119 1.16744 1.16637 1.15982 1.14702 1.12854 1.12101
0 3 NUMBER	3 OF	0.490680 REFLECTIONS	0.490405 = 76	0.000275	1.09960
NUMBER	OF R	EFLECTIONS US	ED = 76 FOR	A GATE OF	0.00030
		PARAMETERS	STANDARD DEV	IATIONS	LAST SHIFTS
A B C	: : :	= 9.888949 = 3.918662 = 6.117504	0.00045 0.00016 0.00024	2 4 3	-0.000000 0.000000 0.000000

H K L SINSQ(D) SINSQ(C) OBS-CALC D OBS MAVELENGTH 1.54051 1 1 0 0.017300 0.017306 -0.000006 5.85614 0 0 1 0.034510 0.034508 0.000002 4.14631 1 3 0 0.050440 -0.000011 3.42895 2 2 0 0.069230 0.000002 2.97144 2 1 0.007720 0.000012 2.96416 2 1 0.007760 0.018971 0.000012 2.97144 2 1 0.016760 0.118971 0.000012 2.9714 3 1 0.1122600 0.1127360 0.000014 2.19983 0 0 2.0138030 0.0153751 0.000014 2.19983 1 5 1 0.153478 0.000014 1.9795117 3 1 0.157170 0.000013 1.77351 3 1 0.15	REFIN	EMENT	OF				,
H K L SINSQIC) DBS-CALC D 0BS WAVELENGTH = 1.54051 1 1 0 0.017300 0.017306 -0.000006 5.85614 0 0 1 0.034510 0.034508 0.000002 4.14631 1 3 0 0.050460 0.050471 -0.000017 2.92744 1 3 1 0.067230 0.000072 2.92744 2 0 1.003760 0.013730 0.000002 2.9122 2 1 0.016720 0.1007151 2.25524 2 4 0.119606 0.118971 0.000012 2.9983 3 1 0.151300 0.151309 0.000047 1.99351 1 5 1 0.151300 0.151309 0.000047 1.99351 3 1 0.151300 0.151309 0.000041 1.97925 3 1 0.155400 0.180511 0.0000121 1.77925				03 08		IBIC	
WAVELENGTH = 1.54051 1 1 0 0.017300 0.017306 -0.000006 5.85614 0 0 1 0.03510 0.034508 0.000002 4.14631 1 3 0 0.050460 0.050471 -0.000011 3.42895 2 0 0.069230 0.064979 0.000001 2.92744 1 3 1 0.013730 0.000007 2.92744 1 3 1 0.013730 0.000030 2.39122 1 5 0.116650 0.118971 0.000039 2.23230 3 1 0.112600 0.122786 0.000047 1.99331 0 0 2.0138090 0.138751 0.000047 1.99351 1 5 1.0151350 0.153786 0.000129 1.953117 3 1 0.157540 0.000039 1.97391 3 1 0.157540 0.000016 1.94327 0 0 0.210470 0.210547 0.000017 1.75546 2 0	н	к	L	SINSQ(0)	SINSQ(C)	OBS-CALC	D OBS
1 1 0 0.017300 0.017306 -0.000006 5.85614 0 0 1 0.0354510 0.034508 0.000002 4.14631 1 3 0 0.050460 0.050471 -0.000017 2.92744 1 3 1 0.085120 0.084979 0.000007 2.92744 2 0 1.085120 0.08148 -0.000028 2.60961 2 2 1 0.103760 0.1000370 2.92744 2 0 0.118670 0.118671 0.000030 2.39122 1 5 0 0.116650 0.116801 -0.00151 2.2524 2 4 0 0.119060 0.118971 0.000047 1.99351 1 5 1 0.151350 0.153478 0.000112 1.96541 3 0 0.15794 0.000041 1.97990 2.4 1 0.157094 0.00012 1.776251 3 1 0.15710 0.157751 0.000091 1.775454 3 1 0.190350	W	AVELEN	NGTH	= 1.54051			
$\begin{array}{cccccccccccccccccccccccccccccccccccc$	1 01212212300123301324424113340305241	1 0 3 2 3 0 2 5 4 1 6 3 3 6 0 2 6 0 7 5 5 1 2 6 3 0 1 6 0 3 6 0 2 6 0 7 5 5 1 2 6 3 0 1 6 0 3 1 6 0 3 1 6 0 3 1 6 0 3 1 6 0 3 1 6 0 3 1 6 0 3 1 6 0 3 1 6 0 3 1 6 0 3 1 6 0 3 1 6 0 3 1 6 0 3 1 6 0 3 1 1 0 3 1 6 0 3 1 6 0 3 1 6 3 1 6 3 1 6	01001110002011011210000111121212230223	$\begin{array}{c} - 1.94091 \\ 0.017300 \\ 0.034510 \\ 0.050460 \\ 0.069230 \\ 0.085020 \\ 0.087120 \\ 0.103760 \\ 0.103760 \\ 0.119060 \\ 0.122600 \\ 0.138090 \\ 0.122600 \\ 0.138090 \\ 0.149290 \\ 0.151350 \\ 0.153590 \\ 0.153590 \\ 0.155840 \\ 0.157110 \\ 0.153590 \\ 0.155840 \\ 0.157110 \\ 0.153590 \\ 0.155840 \\ 0.190350 \\ 0.201940 \\ 0.210470 \\ 0.210470 \\ 0.227130 \\ 0.236350 \\ 0.245050 \\ 0.256690 \\ 0.260790 \\ 0.261560 \\ 0.260790 \\ 0.261560 \\ 0.287280 \\ 0.293740 \\ 0.310580 \\ 0.339940 \\ 0.348700 \\ 0.360980 \\ \end{array}$	0.017306 0.034508 0.050471 0.069223 0.084979 0.087148 0.103730 0.116801 0.118971 0.122586 0.138030 0.149243 0.151309 0.153478 0.155751 0.157094 0.183751 0.188501 0.190259 0.201884 0.210561 0.227143 0.236391 0.245068 0.250805 0.254832 0.256589 0.260617 0.261651 0.287274 0.293782 0.310569 0.333147 0.339914 0.348591 0.361039	$\begin{array}{c} -0.000006\\ 0.000002\\ -0.000011\\ 0.000007\\ 0.000041\\ -0.000028\\ 0.000030\\ -0.000151\\ 0.000089\\ 0.000014\\ 0.000041\\ 0.000041\\ 0.000041\\ 0.000041\\ 0.000112\\ 0.000041\\ 0.0000129\\ 0.000016\\ 0.000129\\ 0.000016\\ 0.0000129\\ 0.000016\\ 0.0000129\\ 0.000016\\ 0.0000129\\ 0.000011\\ 0.000056\\ -0.000091\\ 0.000056\\ -0.000091\\ 0.000056\\ -0.000091\\ 0.000013\\ -0.000013\\ -0.000015\\ -0.000015\\ -0.000015\\ -0.000015\\ -0.000015\\ -0.000006\\ -0.000006\\ -0.000006\\ -0.000006\\ -0.000006\\ -0.000001\\ 0.000006\\ -0.0000026\\ 0.0000059\\ -0.000059\\ \end{array}$	5.85614 4.14631 3.42895 2.92744 2.64164 2.60961 2.39122 2.25524 2.23230 2.19983 2.07278 1.99351 1.97990 1.96541 1.95117 1.94327 1.79625 1.77391 1.76546 1.71405 1.67896 1.61621 1.58437 1.55599 1.53799 1.52629 1.52030 1.50830 1.50608 1.43708 1.43708 1.43708 1.43708 1.42119 1.38213 1.33423 1.32109 1.30439 1.28201
$\begin{array}{rrrrrrrrrrrrrrrrrrrrrrrrrrrrrrrrrrrr$	2	0	3	0.363130	0.363209	-0.000079	1.27821
$\begin{array}{rcrcrcrcrcrcrcrcl} 4 & 6 & 1 & 0.394270 & 0.394312 & -0.000042 & 1.22670 \\ 5 & 3 & 1 & 0.400680 & 0.400820 & -0.000140 & 1.21685 \\ 3 & 1 & 3 & 0.433100 & 0.433155 & -0.000055 & 1.17042 \\ \end{array}$ $\begin{array}{rcrcrcrcrcrcrcrcrcrcrcrcrcrcrcrcrcrcrc$	1	5 9	1	0.383330	0.383465	-0.000122	1.24408
$\begin{array}{rcrcrcccccccccccccccccccccccccccccccc$	4	6	1	0.394270	0.394312	-0.000042	1.22670
NUMBER OF REFLECTIONS = 42 NUMBER OF REFLECTIONS USED = 42 FOR A GATE OF 0.00020 PARAMETERS STANDARD DEVIATIONS LAST SHIFTS A = 6.714377 0.000379 0.000000 B = 11.962947 0.000902 0.000000 C = 6.106455 0.000276 0.000000	3	1	3	0.433100	0.433155	-0.000055	1.17042
NUMBER OF REFLECTIONS USED = 42 FOR A GATE OF 0.00020 PARAMETERS STANDARD DEVIATIONS LAST SHIFTS A = 6.714377 0.000379 0.000000 B = 11.962947 0.000902 0.000000 C = 6.166656 0.000276 0.000000	N	UMBER	OF	REFLECTION	S = 42		
PARAMETERS STANDARD DEVIATIONS LAST SHIFTS A = 6.714377 0.000379 0.000000 0.000000 B = 11.962947 0.000902 0.000000 0.000000	N	UMBER	OF I	REFLECTIONS	USED = 42 F	OR A GATE OF	0.00020
A= 6.714377 0.000379 0.000000 B= 11.962947 0.000902 0.000000 C= 6.166656 0.000376 0.000000				PARAMETER	S STANDARD	DEVIATIONS	LAST SHIFTS
B = 11.962947 0.000902 0.000000		A		= 6.71437	7 0.00	0379	0.000000
		B C		= 11.96294 = 4.14645	7 0.00 6 0.00)0902)0276	0.000000

REFIN	EMENT	OF	U	SI		ORTHORHOMBIC			,		
н	к	L		SINSQ(0)		SIN	SQ(C)	OBS-CALC	DO	BS
W	AVELE	NGTH	=	1.54051							
12021212313041243221123350155442501262365105 N	001011010112022110210200010022133313212321 JMBER	10111021121011002313233114412313211001311243 F	R	0.028658 0.040369 0.057505 0.058877 0.067618 0.079427 0.084110 0.097913 0.109431 0.123263 0.148409 0.156207 0.179937 0.184705 0.196512 0.200442 0.203899 0.206972 0.214910 0.215628 0.240291 0.245903 0.257421 0.265527 0.271050 0.296057 0.305958 0.310048 0.326274 0.328034 0.326577 0.305958 0.310048 0.326274 0.328034 0.365315 0.369773 0.380056 0.391977 0.402368 0.410344 0.435636 0.452135 0.457854 EFLECTION	IS	$\begin{array}{c} 0 & 0 & 0 \\ 0 & 0 & 0 \\ 0 & 0 & 0 \\ 0 & 0 &$	28599 40384 57888 57888 57888 57888 57888 5794992 40354 56092 57888 5794992 57888 5794992 57888 5794992 57888 5794992 57888 5794992 57888 579492 57888 579492 57888 579492 57888 579492 57888 579492 57888 579492 57888 579492 57888 579492 57888 579492 57888 579492 57888 579492 57888 579492 57888 579592 57888 579592 579592 579595 5795555 579555 5795555 579555 579555 5795555 5795555 579555 579555 579555 5795555 5795555 579555 5795555 5795555 5795555 5795555 5795555 5795555 5795555 5795555 5795555 5795555 5795555 5795555 5795555 57955555 57755555 57755555 57755555 57755555 57755555 57755555 57755555 577555555 57755555 57755555 577555555 57755555 57755555 577555555 577555555 5775555555 577555555 577555555 577555555 577555555 577555555 577555555 577555555 5775555555 5775555555 57755555555	50904959443782673064294120512356233252159372	0.000063 -0.00002 -0.00002 -0.00002 -0.00002 -0.000015 -0.000015 -0.000019 0.000010 -0.000081 -0.000081 -0.000081 -0.000086 -0.000086 -0.000064 -0.000055 -0.0000166 -0.0000166 -0.0000166 -0.0000166 -0.000026 0.000026 0.000027 -0.000027 -0.000027 -0.000137 0.000127 -0.000137 0.000127 -0.000137 0.000155 -0.000117 0.000155 -0.000169 0.0000155 -0.000098 0.000051 0.000098 0.000098 0.000098 0.000098 0.000098 0.000098 0.000098	4.55 3.83 3.21 3.17 2.96 2.73 2.65 2.46 2.32 2.19 1.99 1.94 1.812 1.73 1.72 1.652 1.652 1.652 1.652 1.652 1.652 1.652 1.652 1.652 1.624 1.274 1.260 1.274 1.260 1.274 1.260 1.274 1.260 1.274 1.260 1.274 1.260 1.274 1.260 1.274 1.260 1.274 1.260 1.274 1.260 1.1274 1.260 1.274 1.260 1.1274 1.260 1.1274 1.260 1.274 1.260 1.1274 1.260 1.274 1.260 1.176 1.	002 361 209 213 598 213 598 8912 883 988 522 504 508 839 2256 40 508 839 2256 40 508 5255 1329 498 52551 848 52551 848 52551 848 52551 848 52551 848 52551 848 52551 848 52551 848 535 590 848 500 500 500 500 500 500 500 500 500 50
NL	JMBER	OF F	REF	LECTIONS	US	ED =	44	FOR	A GATE OF	0.00	0020
				PARAMETER	S	STAN	IDAR	DE	VIATIONS	LAST	SHIFTS

Α	=	7.666263	0.000405	-0.000000
В	=	3.897880	0.000194	0.00000
С	=	5.663025	0.000375	0.000000

REFINEMENT OF P			>	ORTHORHOMBIC		
н	к	L	SINSQ(0)	SINSQ(C)	OBS-CALC	D OBS
۸W	VELEN	IGTH =	· 1.54051			
0 0 1 0 1 1 2 1 1 2 0 2 2 2 2 2	22410310532224064	0 1 2 1 2 0 1 2 0 1 2 0 1 3 0 2 0 2	0.021590 0.052520 0.086430 0.090360 0.123840 0.133650 0.183330 0.215990 0.220000 0.226550 0.237660 0.268630 0.300320 0.302440 0.340060 0.410720 0.426480	0.021610 0.052580 0.086440 0.090393 0.123879 0.133613 0.183303 0.216084 0.220053 0.226523 0.227694 0.268664 0.300338 0.302524 0.339963 0.410574 0.426403	$\begin{array}{c} -0.000020\\ -0.000060\\ -0.000033\\ -0.000033\\ -0.000037\\ 0.000027\\ -0.000094\\ -0.000094\\ -0.000053\\ 0.000027\\ -0.000034\\ -0.000034\\ -0.000034\\ -0.000018\\ -0.000084\\ 0.000097\\ 0.000146\\ 0.000077\end{array}$	5.24214 3.36103 2.62001 2.56240 2.18879 2.10693 1.79894 1.65736 1.64219 1.61828 1.58000 1.48613 1.40554 1.40060 1.32086 1.20188 1.17947
1	7	2	0.442600	0.442622	-0.000022	1.15779
NU	IMBER	OF RE	EFLECTIONS U	SED = 18 F STANDARD	OR A GATE OF DEVIATIONS	0.00030 Last shifts
	A B	=	= 3.314005 = 10.479428	0.00	0242 1141	0.000000 0.000000
	С	=	4.376888	0.00	0407	0.000000

REFI	NEMENT	OF				
			RE3 GE7	OR THOROMB I	C CMCM	,
н	к	L	SIN SQ (O)	SINSQ(C)	OBS-CALC	D CBS
ŀ	VAVELE	NGTH	= 1.54051			
D	0	2	0.004870	0.004920	-0.000050	11.03748
0	0	4	0.019590	0.019678	-0.000088	5.50323
0	2	0	0.028980	0.029012	-0.000032	4.52466
0	2	1	0.040010	0.030242	-0.000042	4.43232
õ	õ	6	C.C44260	0.044276	-0.000016	3.66125
ō	2	4	0.048670	0.048691	-0.000021	3.49143
0	2	5	0.059670	0.059760	-0.000090	3.15324
1	1	0	0.064150	0.064218	-0.000068	3.04114
1	1	2	0.073270	0.069137		2.92955
1	2	3	0.075230	0.075287	-0.000019	2.80827
ī	ī	4	0.083900	0.083896	0.000004	2.65921
0	2	7	0.089230	0.089277	-0.000047	2.57857
1	1	5	0.094970	0.094965	0.000005	2.49943
0	2 4	2	0.120890	0.120969	-0.000046	2.21533
ĩ	3	ō	0.122200	0.122243	-0.000043	2.20343
0	0	10	0.122890	0.122990	-0.000100	2.19723
1	1	7	0.124410	0.124483	-0.000073	2.18377
0	4	ر 4	0.135700	0.127119	-0.000099	2.09095
1	3	4	0.141910	0.141921	-0.000011	2.04469
1	1	8	0.142950	0.142931	0.000019	2.03724
0	4	5	0.146820	0.146797	0.000023	2.01021
1	2	10	0.151930	0.152002	-0.000072	1.97612
1	3	6	0.166440	0.166519	-0.000079	1.88802
0	4	7	0.176260	0.176315	-0.000055	1.83467
0	2	11	0.177790	0.177830	-0.000040	1.82676
1	5 1	10	0.182440	0.187207	-0.000068	1.80333
ō	4	8	0.194730	0.194763	-0.000033	1.74549
1	3	8	0.200940	0.200956	-0.000016	1.71831
0	2	12	0.206070	0.206118	-0.000048	1.69679
2	4	0	0.227800	0.227859	-0.000191	1.61383
ō	2	13	0.236810	0.236865	-0.000055	1.58283
1	5	0	0.238190	0.238292	-0.000102	1.57824
0	0	14	0.241170	0.241060	0.000110	1.56846
1 2	6	10	0.245400	0+245232 0-247537	-0.000168	1.54830
1	5	3	0.249320	0.249361	-0.000041	1.54261
2	2	0	0.256750	0.256871	-0.000121	1.52012
1	5	4	0.258010	0.257970	0.000039	1.51641
0	0 6	2	0.262380	0.262342	-0.000038	1.49343
2	2	3	0.268000	0.267940	0.000060	1.48788
1	5	5	0.268880	0.269040	-0.000160	1.48544
0	6	3	0.272210	0.272181	0.000029	1.47633
2	∠ 5	4 K	0.282540	U+210049 0.282568	-0.000001 -0.000028	1.404/0
2	2	5	0.287610	0.287618	-0.000008	1.43626
0	6	5	0.291850	0.291859	-0.000009	1.42579
0	4	12	0.293100	0.293155	-0.000055	1.42274

1	3	12	0.299 37 0	0.299348	0.000022	1.40777
2	2	6	0.301370	0.301147	0.000223*	1.40309
0	6	6	0.305390	0.305388	0.000002	1.39382
0	2	15	0.305670	0.305739	-0.000069	1.39318
0	0	16	0.314790	0.314854	-0.000064	1.37285
2	2	7	0.317230	0.317136	0.000094	1.36756
0	4	13	0.323870	0.323902	-0.000032	1.35347
1	3	13	0.330200	0.330095	0.000105	1.34044
2	2	8	0.335610	0.335584	0.000026	1.32959
1	5	9	0.338090	0.337914	0.000176	1.32470
0	6	8	0.339690	0.339825	-0.000135	1.32158
1	1	15	0.340870	0.340945	-0.000075	1.31929
0	2	16	0.343830	0.343866	-0.000036	1.31360
2	4	2	0.348820	0.348828	-0.000008	1.30417
2	0	10	0.350900	0.350848	0.000052	1.30030
2	4	3	0.354900	0.354977	-0.000077	1.29295
0	4	14	0.357170	0.357109	0.000061	1.28883
1	5	10	0.361190	0.361282	-0.000092	1.28164
1	3	14	0.363350	0.363302	0.000048	1.27783
2	4	5	0.374790	0.374656	0.000134	1.25817
2	2	10	0.379880	0.379861	0.000019	1.24972
0	2	17	0.384490	0.384453	0.000037	1.24220
2	4	6	0.388010	0.388184	-0.000174	1.23655
0	4	15	0.392760	0.392776	-0.000016	1.22905
1	3	15	0.399110	0.398969	J.000141	1.21924
2	4	7	0.404250	0.404173	0.000077	1.21146
2	2	11	0.405660	0.405688	-0.000029	1.20935
1	7	0	0.412290	0.412367	-0.000077	1.19959
1	7	1	0.413510	0.413596	-0.00086	1.19782
1	1	2	0.417390	0.417286	0.000104	1.19224
2	4	8	0.422870	0.422622	0.000248*	1.18449
0	2	18	0.427380	0.427499	-0.000119	1.17822
1	1	4	0.432190	0.432045	0.000145	1.1/165
2	2	12	0.434050	0.433976	0.000074	1.16914
1	3	10	0.437270	0.437096	0.000174	1.16482
1	כ ד	13	0.446310		0.000165	1.15296
1 1	1	10	0 442000	0.420042	0.000037	1 12212
1	1	10	0.402900	0 462704	0.000066	1.12004
2	2	15	0 460100	0.460119	0.000040	1.124504
U 1	0 7	27	0 409190	0 472622	0.000072	1 12020
<u> </u>	I Q	י 2	0.475250	0.475262	0.000100	1,11710
0	Q Q	2	0.483900	0.483877	0.00002	1.10720
1	7	-т 8	0.401190	0.491080	0.00010	1.09904
-	T	0	014)1100	94-17100U	JICOSICO	

NUMBER OF REFLECTIONS = 99

NUMBER O	FRI	EFLECTIONS USE	D = 97 FOR A GATE OF	0.00020			
		PARAMETERS	STANDARD DEVIATIONS	LAST SHIFTS			
Α	:	= 3.227244	0.000169	-0.000000			
8	:	= 9 .044252	0.000316	-0.000000			
С	:	= 21.963430	0.000887	0.000000			
н	к	L	SINSQ(O)	SINSQ(C)	OBS-CALC	D OBS	
--	--	---	---	--	---	---	--
WAY	VELEN	IGTH :	= 1.54051				
H WAN 101-110021021-21122021-23201131230101212122131204040	K L L L L L L L L L L L L L L L L L L L	L IGTH 010112002102121222202120133011212331332302212131420C113	SINSQ(0) = 1.54051 0.022933 0.043409 0.044768 0.059200 0.073439 0.086183 0.091834 0.091834 0.094738 0.109042 0.113596 0.116544 0.120986 0.123316 0.124756 0.145262 0.149377 0.17589 0.173617 0.179328 0.182307 0.186617 0.206252 0.206656 0.215161 0.2157777 0.217474 0.219589 0.228696 0.234223 0.236923 0.248210 0.260165 0.264832 0.271633 0.281290 0.282638 0.281290 0.282638 0.281290 0.282638 0.281290 0.282638 0.281290 0.282638 0.281290 0.282638 0.281290 0.282638 0.281290 0.282638 0.281290 0.282638 0.234628 0.234593 0.321365 0.337305 0.337305 0.337839 0.3459458 0.367598 0.367598 0.371458 0.382362 0.29400	SINSQ(C) 0.022975 0.043396 C.044838 0.059232 0.073511 0.086132 0.087453 0.091899 0.094828 0.108986 0.113763 0.126691 0.121017 0.123386 0.124822 0.145250 0.149473 0.171337 0.173586 0.179353 0.182281 0.186606 0.206590 0.206774 0.215165 0.215661 0.215661 0.215661 0.215750 0.228751 0.234138 0.260955 0.2647759 0.282807 0.382482 0.307146 0.38046	-0.000042 0.000013 -0.000070 -0.000032 -0.000050 -0.000065 -0.000065 -0.000167 -0.000167 -0.000012 -0.000012 -0.000012 -0.000012 -0.000012 -0.000012 -0.000012 -0.000012 -0.000012 -0.000012 -0.000012 -0.000012 -0.000012 -0.000012 -0.000017 -0.0000156 -0.0000156 -0.000055 0.0000156 -0.0000156 -0.0000156 -0.0000156 -0.0000156 -0.0000156 -0.0000156 -0.0000156 -0.0000156 -0.0000045 -0.0000045 -0.0000045 -0.0000045 -0.0000045 -0.0000045 -0.0000045 -0.0000045 -0.0000045 -0.000012 -0.000012 -0.000012 -0.000012 -0.0000156 -0.0000005 -0.0000000 -0.00000000 -0.0000000 -0.0000000 -0.0000000 -0.0000000 -0.0000000 -0.0000000 -0.0000000 -0.0000000 -0.0000000 -0.0000000 -0.0000000 -0.000000000 -0.0000000 -0.0000000 -0.0000000 -0.0000000 -0.0000000 -0.000000000 -0.0000000000	D OBS 5.08630 3.69694 3.64043 3.16573 2.84231 2.62376 2.60524 2.54175 2.50249 2.33259 2.25626 2.21445 2.19343 2.18074 2.02096 1.99294 1.85948 1.81891 1.80398 1.78303 1.69604 1.69438 1.66055 1.65818 1.66055 1.65818 1.66170 1.64373 1.61066 1.59155 1.58245 1.54605 1.59155 1.58245 1.54605 1.51012 1.49675 1.54605 1.51012 1.49675 1.44884 1.44812 1.44812 1.44812 1.44812 1.44812 1.43319 1.42622 1.42028 1.41563 1.36134 1.35031 1.32624 1.32324 1.32958 1.30199 1.227042 1.26380 1.24565	
0 -4 -2 3 2 -3	3 0 1 3 2 2	3 4 2 4 0 3 3	0.390400 0.395961 0.396695 0.401292 0.403501 0.416064 C.4241C4	0.390568 0.396063 0.396613 0.401175 0.403543 0.415988 0.423768	-0.000168 -0.000102 0.000082 0.000116 -0.000042 0.000042 0.0000336	1.23276 1.22408 1.22294 1.21592 1.21258 1.19414 1.18276	
-1 0 1 -2 3 -2 4 -3 2 1 3 2	2 2 3 3 4 2 0 4 2 1 0	4 3 3 1 1 0 4 1 4 3	C.426087 0.432292 0.435151 0.439320 0.446488 0.448672 C.455233 0.465376 0.477676 0.483458 0.48653 0.48653	0.426399 0.431983 0.434961 0.439629 0.446495 0.448966 0.455051 0.465628 0.477525 0.483516 0.486691	-0.000312 0.000309 0.000190 -0.000310 -0.000008 -0.000294 0.000182 -0.000252 0.000151 -0.000058 -0.000089	1.18001 1.17151 1.16765 1.16210 1.15274 1.14993 1.14161 1.12910 1.11447 1.10778 1.0420 1.09415	
- 4 4	1	3 05	0.497744	0.497583	0.000160	1.09177	
NUM	DEK	ur 05	REFLECTIONS	- 14		A	
NUM	BER	UF RE	PARAMETERS	SED = 74 FO	R A GATE OF	0.00040	
	A B C BE	= = = TA =	5.148434 5.209265 5.317997 99.235773	0.000 0.000 0.000 0.000 0.006	410 413 381 552	0.000000 0.000000 -0.000000 -0.000000	

REFINEMENT OF ZR O2

MONOCLINIC

,

REFINEMENT OF

BA CL2.2H2 O MONOCLINIC

.

н	к	L	SINSQ(0)	SINSQ(C)	OBS-CALC	D 085
WΑ	VELEN	GTH =	= 1 . 54051			
WA 0 -1 -1 -1 0 -1 -1 0 0 2 0 2 1 -2 -1 -2 -1 -2 0 -2 -1 -2 -2 -2 0 -2 -2 -2 -2 -2 -2 -2 -2 -2 -2	VELEN 1 1 2 0 0 1 1 2 2 0 1 3 1 3 1 2 2 2 4 	GTH = 1 0 1 1 1 1 1 1 2 0 1 0 0 2 1 1 0 2 1 1 0 0 1 1 1 1 1 1 1 1 1 1 1 1 1	<pre>= 1.54051 0.016650 0.018040 0.019940 0.024330 0.025240 0.029260 0.030250 0.031620 0.044180 0.045160 0.045160 0.056580 0.051640 0.056580 0.0557470 0.056580 0.0557470 0.056580 0.057470 0.056580 0.069160 0.069160 0.069160 0.07012C 0.072490 0.080650 0.083220 0.091430</pre>	0.016654 0.018122 0.019944 0.024328 0.025280 0.029314 0.030266 0.031612 0.044272 0.046672 0.051658 0.052543 0.056542 0.056542 0.057529 0.058010 0.065746 0.068245 0.068245 0.068245 0.068245 0.070149 0.072487 0.080704 0.083203 0.091445	$\begin{array}{c} -0.000004\\ -0.000082\\ -0.000002\\ -0.000040\\ -0.000054\\ -0.000054\\ -0.000092\\ -0.000092\\ -0.000064\\ -0.000022\\ -0.000018\\ -0.000073\\ 0.000038\\ -0.000055\\ -0.000055\\ -0.000055\\ -0.000055\\ -0.000055\\ -0.000055\\ -0.000054\\ 0.000017\\ -0.000015\end{array}$	5.96936 5.73478 5.45472 4.93814 4.84831 4.50295 4.42866 4.33165 3.66456 3.62458 3.56623 3.38955 3.36263 3.23820 3.21302 3.19748 3.00459 2.94967 2.92892 2.90880 2.86085 2.71227 2.67006 2.54736
$ \begin{array}{c} 1 \\ -2 \\ -2 \\ -1 \\ 2 \\ -1 \\ 2 \\ -1 \\ 1 \\ -2 \\ 3 \\ 1 \\ -1 \\ 1 \\ -2 \\ 2 \\ -3 \\ 1 \\ -1 \\ 1 \\ -2 \\ 2 \\ -3 \\ 1 \\ -1 \\ 1 \\ -2 \\ 2 \\ -3 \\ 1 \\ -1 \\ -2 \\ 2 \\ -3 \\ 1 \\ -1 \\ -2 \\ 2 \\ -3 \\ 1 \\ -1 \\ -2 \\ 2 \\ -3 \\ 1 \\ -1 \\ -2 \\ -3 \\ -1 \\ -1 \\ -2 \\ -3 \\ -1 \\ -1 \\ -2 \\ -3 \\ -1 \\ -2 \\ -3 \\ -1 \\ -2 \\ -3 \\ -1 \\ -1 \\ -2 \\ -3 \\ -1 \\ -1 \\ -2 \\ -3 \\ -2 \\ -3 \\ -1 \\ -2 \\ -3 \\ -1 \\ -2 \\ -3 \\ -2 \\ -3 \\ -1 \\ -2 \\ -3 \\ -2 \\ -2 \\ -3 \\ -2 \\ -2 \\ -3 \\ -2 \\ -2 \\ -3 \\ -2 \\ -2 \\ -2 \\ -2 \\ -2 \\ -2 \\ -2 \\ -2$	4 4 0 0 1 4 1 3 1 0 0 2 1 0 4 1 5 4 2 4 3 4 3 2 5	1 0 2 2 2 1 2 1 3 3 2 3 1 0 1 0 2 3 2 2 1 2 1 2 1 2 1 2 1 2 1 2 1 2 1 2	C.092840 C.092840 O.097300 O.101C70 O.102240 O.104060 O.106090 O.108130 O.109960 O.116640 O.119580 O.120960 O.121660 O.128430 C.132250 O.132250 O.136290 O.137750 O.138610 O.139430 O.140550 O.14250 O.14550 O.145920 O.146920	0.091443 0.092913 0.097311 0.101120 0.102297 0.104104 0.106106 0.108133 0.109998 0.116719 0.119576 0.121064 0.121706 0.128462 0.132320 0.136304 0.137787 0.138632 0.139520 0.140537 0.142185 0.144940 0.145994 0.148904	$\begin{array}{c} -0.000013\\ -0.000073\\ -0.000050\\ -0.000057\\ -0.000057\\ -0.000016\\ -0.000038\\ -0.000038\\ -0.000038\\ -0.0000046\\ -0.0000104\\ -0.0000104\\ -0.0000104\\ -0.0000104\\ -0.000014\\ -0.000014\\ -0.000014\\ -0.0000013\\ 0.000065\\ -0.000020\\ -0.0000104\\ 0.000004\\ -0.0000104\\ -0.0000104\\ -0.0000104\\ -0.0000104\\ -0.0000104\\ -0.000011\\ -0.000001\\ -0.000000\\ -0.000000\\ -0.000000\\ -0.000000\\ -0.000000\\ -0.000000\\ -0.000000\\ -0.000000\\ -0.000000\\ -0.000000\\ -0.000000\\ -0.000000\\ -0.0000\\ -0.00000\\ -0.00000\\ -0.0000\\ -0.00000\\ -0.00000\\ -0.000\\ -0.0000\\ -0.0000\\ -0.0000\\ -0.000\\ -0.000\\ -0.0000\\ -0.$	2.54736 2.52794 2.46932 2.42283 2.40893 2.38777 2.36482 2.34240 2.32283 2.25533 2.22744 2.21469 2.20831 2.14932 2.11805 2.08642 2.07534 2.06889 2.06280 2.05456 2.04225 2.02335 2.01661 1.999422
$ \begin{array}{c} 1 \\ 3 \\ -3 \\ 0 \\ 2 \\ 0 \\ -2 \\ 0 \\ 3 \\ 1 \\ -1 \\ 2 \\ 0 \\ -3 \\ 4 \\ 3 \\ 2 \\ 0 \\ 0 \\ 0 \\ \end{array} $	535336405564416324311553	10211024110341203234	0.149920 0.163010 0.171340 0.173230 0.176260 0.1796C0 0.180800 0.186740 0.187810 0.187810 0.191280 0.199440 0.202940 0.203900 0.205310 0.205310 0.206620 0.208080 0.212510 0.223840 0.225920 0.229850 0.231480	0.149931 0.163096 0.171323 0.173336 0.176193 0.179498 C.180896 0.186688 0.187910 0.189815 0.191166 0.197999 0.199353 0.202705 0.203826 0.205286 0.206632 0.208238 0.212625 0.215158 0.225771 0.229663 0.231563	-0.000011 -0.000086 0.000017 -0.000106 0.000067 0.000052 -0.000005 0.000100 -0.000005 0.000114 0.0000114 0.000035 0.000012 -0.000012 -0.000012 -0.000158 -0.000115 -0.000048 -0.000048 -0.000149 0.000187 -0.000083	1.98932 1.90778 1.86082 1.85065 1.83467 1.81753 1.81149 1.78244 1.77736 1.76797 1.76116 1.73058 1.70579 1.69992 1.69453 1.68857 1.67088 1.66857 1.66075 1.62804 1.62053 1.60662 1.60095

-2	0	4	0.235380	0.235422	-0.000042	1.58763
-1	6	2	0.238300	0.238353	-0.000053	1.57787
ī	6	2	0.240210	0.240258	-0.000048	1.57159
-3	4	2	0.241820	0.241814	0.000006	1.56635
2	6	1	0.244600	0.244661	-0.000061	1.55742
2	2	2	0 247200	0 247463	-0.000073	1 54941
2	2	2	0 247390	0.241403	-0.000075	1 6/477
2	1	4	0.247980	0.248028	-0.000048	1.54077
-3	5	1	0+253120	0.253113	0.000007	1.53099
4	3	0	0.255180	0.255047	0.000133	1.52479
3	5	1	0.255840	0.255970	-0.000130	1.52283
1	7	0	0.257470	0.257452	0.00018	1.51800
- 4	1	2	0.258020	0.258022	-0.000002	1.51638
4	0	2	0.260420	0.260653	-0.000233*	1.50938
-3	3	3	0.263820	0.263823	-0.000003	1.49962
ō	4	4	0.266470	0.266465	0.000005	1.49214
-4	,	2	0 273050	0.272980	0.000070	1 47405
	2	2	0 200450	0 200417	0.000010	1.45204
2	0	2	0.280890	0.200017	0.000032	1.40040
2	2	3	0.285080	0.285063	0.000017	1.44262
2	3	4	0.287850	0.287915	-0.000065	1.43566
4	4	0	0,289940	0.289949	-0.000009	1.43048
3	5	2	0.292550	0.292402	0.000148	1.42408
3	6	0	0.297780	0.297720	0.000060	1.41152
1	6	3	0.299090	0.299074	0.000016	1.40842
4	4	1	0.303380	0.303522	-0.000142	1.39843
i	7	2	0.305110	0.305077	0 000033	1 39446
_ 2	7	1	0 207590	0 207575	0.0000005	1 20005
-2		1	0.313310	0.313203	0.000005	1.37000
1	1	2	0.312310	0.312203	0.000107	1.37829
-2	4	4	0.315200	0.315199	0.000001	1.37196
1	5	4	0.326500	0.326380	0.000120	1.34801
0	8	1	0.330660	0.330775	-0.000115	1.33950
-5	0	1	0.337540	0.337682	-0.000142	1.32578
4	4	2	0.340490	0.340430	0.000060	1.32003
- 3	6	2	0.341560	0.341535	0.000025	1.31796
-2	ĩ	5	0.344460	0.344468	-0.000008	1.31240
3	,	2	0.347190	0.347249	-0.000059	1 20722
5	5	1	0 349430	0 349304	0 000036	1 30490
7	-	-	0.2(0220	0.340370	0.000034	1 30334
v.	2	2	0.349320	0.349329	-0.000009	1.00324
3	2	و	0.352240	0.352170	0.000070	1.29782
-5	2	1	0.357610	0.357626	-0.000016	1.28804
3	7	0	0.362520	0.362539	-0.000019	1,27929
Û	8	2	0.365760	0.365779	-0.000019	1.27361
2	2	5	0.368950	0.368949	0.000001	1.26809
0	4	5	0.371480	0.371477	0.000003	1.26377
- 1	8	2	0.377880	0.377963	-0.00083	1.25302
1	8	2	0.379700	0.379867	-0.000167	1.25001
-2	, Š	5	0.384360	0.384357	0.000003	1.24241
-4	Ā	á	0.389220	0.389248	-0.000028	1.23463
2	7		0 200440	0 300400	0 000040	1 23270
	7	-	0 309030	0.300015	-0.000006	1 21062
~~~	· ·	2	0.598920	0.399015		1.21933
- 3	0	2	0.402950	0.402780	0.000170	1.21341
2	1	3	0.404670	0.404728	-0.000058	1.21083
4	1	- 4	0.409390	0.409465	-0.000075	1.20383
3	7	2	0.412020	0.412067	-0.000047	1.19998
-5	3	2	0.415220	0.415180	0.000040	1.19535
- 5	4	1	0.417370	0.417459	-0.000089	1.19227
2	6	4	0.422360	0.422538	-0.000178	1.18520
0	ī	6	0.424890	0.425034	-0.000144	1.18167
-5	ĩ	3	0.431370	0.431251	0.000119	1.17276
-4	5	3	0.434090	0.434122	-0.000032	1.16908
2	2	ร์	0.437120	0.437008	0.000112	1.16502
4	~	2	0 440390	0.440151	0.000120	1.16082
-1	7	<u>د</u>	0 443340	0 6400121	0.000127	1 16077
- T	4	4	0 445000	0 1112230		1 15242
L	2	4	0.445800	96440049		1.10002
-4	(	1	0.464320	0.464252	0.00068	1.13038
- 2	9	1	C.467310	0.467129	0.000181	1.12676
0	6	5	0.471360	0.471198	0.000162	1.12191
6	1	0	0.478030	0.477874	0.000156	1.11406
3	6	4	0.490190	0.490121	0.000069	1.10015
- 5	5	2	0.494870	0.494956	-0.000087	1.09494
2	2	6	0.498180	0.498249	-0.000069	1.09129
4	6	3	0.500490	0.500396	0.000094	1.08877
	-	-				
NU	MBER	ÛF	REFLECTIONS	= 143		

.

 NUMBER OF REFLECTIONS USED = 141 FOR A GATE OF
 0.00020

 PARAMETERS
 STANDARD
 DEVIATIONS
 LAST SHIFTS

 A = 6.721821
 0.000209
 -0.000000
 -0.000000

 B = 10.908276
 0.000224
 -0.000000
 0.000000

 C = 7.132084
 0.000224
 -0.000000
 -0.000000

 BETA = 91.101905
 0.002833
 -0.000019

1-340 (See back cover earlier reports.)

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